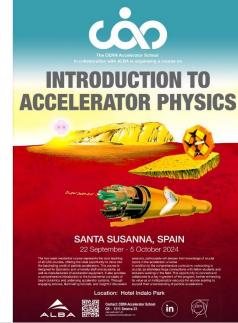


# Beam Instrumentation & Diagnostics Part 2 CAS Introduction to Accelerator Physics Santa Susanna, 1<sup>st</sup> of October 2024 Peter Forck Gesellschaft für Schwerionenforschnung (GSI) p.forck@gsi.de

2<sup>nd</sup> part of this lecture covers:

- Transverse profile techniques
- Emittance determination at transfer lines
- Diagnostics for bunch shape determination



Beam Instrumentation & Diagnostics, Part 2



The beam width can be changed by focusing via quadruples.

Transverse matching between ascending accelerators is done by focusing. → Profiles have to be controlled at many locations.

**Synchrotrons:** Lattice functions  $\beta$  (s) and D(s) are fixed  $\Rightarrow$  width  $\sigma$  and emittance  $\varepsilon$  are:

$$\sigma_x^2(s) = \varepsilon_x \beta_x(s) + \left(D(s)\frac{\Delta p}{p}\right)^2$$
 and  $\sigma_y^2(s) = \varepsilon_y \beta_y(s)$  (no vertical bend)

*Transfer lines:* Lattice functions are 'smoothly' defined due to variable input emittance. *Typical beam sizes:* 

e<sup>-</sup>-beam: typically Ø 0.01 to 3 mm, protons: typically Ø 1 to 30 mm

## A great variety of devices are used:

> Optical techniques: Scintillating screens (all beams),

synchrotron light monitors ( $e^-$ ), optical transition radiation ( $e^-$ , high-energetic p), ionization profile monitors (protons)

> Electronics techniques: Secondary electron emission SEM grids, wire scanners (all beams)

# **Outline:**

Scintillation screens:

emission of light, universal usage, limited dynamic range

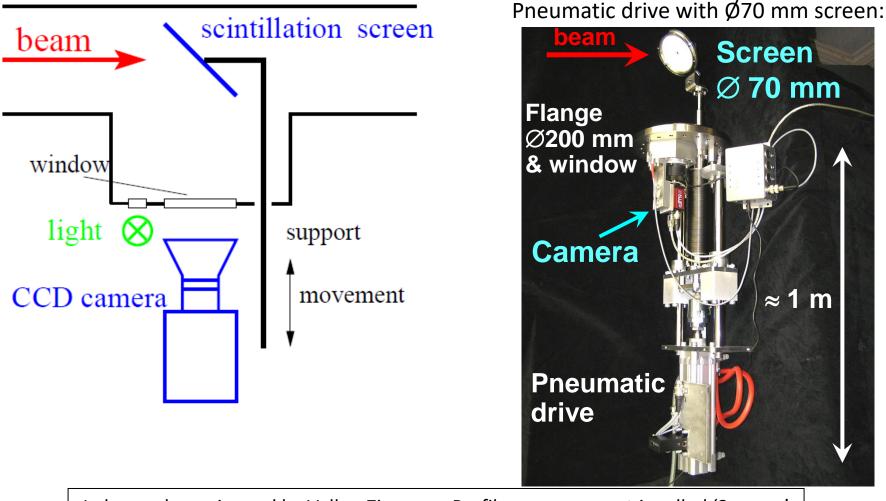
- Optical Transition Radiation
- > SEM-Grid
- Wire scanner
- Ionization Profile Monitor
- Synchrotron Light Monitors
- Summary





### Scintillation: Particle's energy loss in matter causes emission of light

 $\rightarrow$  the most direct way of profile observation as used from the early days on!



In beam dynamics and by Volker Ziemann: Profile measurement is called 'Screens'

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#### Advantage of screens:

- Direct 2-dim measurement
- ➢ High spatial resolution
- ➤ Cheap realization
- $\Rightarrow$  widely used at transfer lines

#### **Disadvantage of screens:**

- Intercepting device
- Some material might be brittle
- Possible low dynamic range
- Might be destroyed

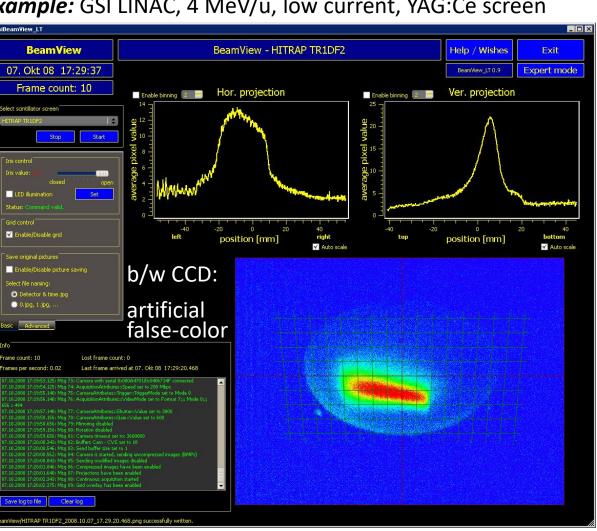
LINAC

- by the beam (radiation damage)
- Observation with CMOS camera Scintillation Screen (beam stopped)

LINAC

#### **Example:** GSI LINAC, 4 MeV/u, low current, YAG:Ce screen



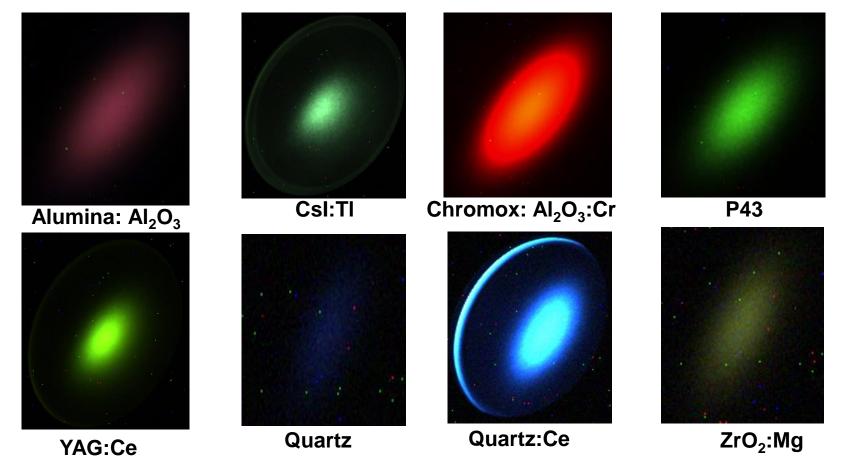




# Light output from various Scintillating Screens



#### Example: Color CCD camera: Images at different particle intensities determined for U at 300 MeV/u



Very different light yield i.e. photons per ion's energy loss

Different wavelength of emitted light



#### Some materials and their basic properties:

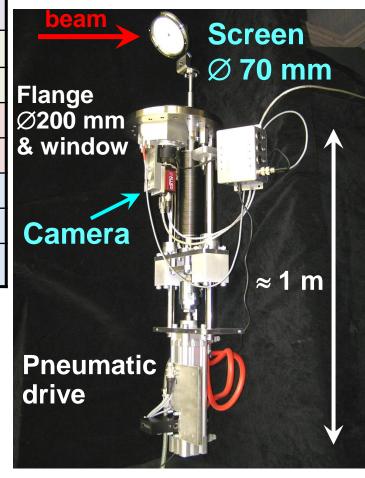
Standard drive with P43 screen

Туре	Name	Material	Activ.	Max. λ	Decay
Cera-	Chromox	Al <sub>2</sub> O <sub>3</sub>	Cr	700nm	≈ 10ms
mics	Alumina	Al <sub>2</sub> O <sub>3</sub>	Non	380nm	≈ 10ns
Crystal	YAG:Ce	$Y_3AI_5O_{12}$	Ce	550nm	200ns
	LYSO	Lu <sub>1.8</sub> Y <sub>.2</sub> SiO <sub>5</sub>	Ce	420nm	40ns
Powder	P43	Gd <sub>2</sub> O <sub>3</sub> S	Tb	545nm	1ms
of gains	P46	$Y_3AI_5O_{12}$	Ce	530nm	300ns
Ø≈10μm on glass	P47	Y <sub>2</sub> SiO <sub>5</sub>	Ce&Tb	400nm	100ns

#### **Properties of a good scintillator:**

- Large light output at optical wavelength
  - ightarrow standard camera can be used
- $\blacktriangleright$  Large dynamic range  $\rightarrow$  usable for different currents
- $\blacktriangleright$  Short decay time  $\rightarrow$  observation of variations
- $\succ$  Radiation hardness → long lifetime
- → Good mechanical properties → typ. size up to Ø 10 cm

(Phosphor Pxx grains of  $\not{Q} \approx 10 \ \mu m$  on glass or metal).



# **Outline:**

Scintillation screens:

emission of light, universal usage, limited dynamic range

Optical Transition Radiation:

light emission due to crossing material boundary, mainly for relativistic beams

- > SEM-Grid
- ➤Wire scanner
- Ionization Profile Monitor
- > Synchrotron Light Monitors
- > Summary

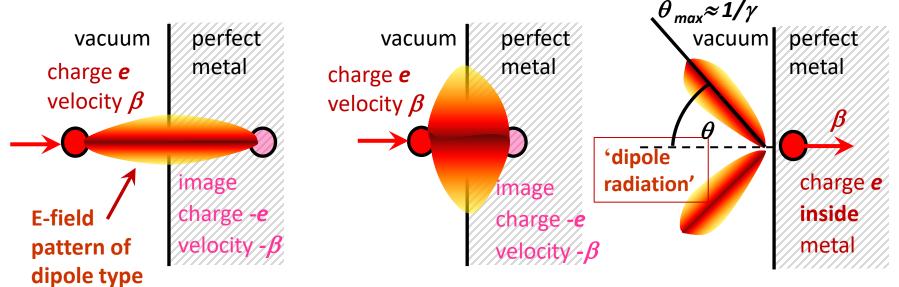




#### **Optical Transition Radiation OTR for a single charge** *e*:

Assuming a charge *e* approaches an ideal conducting boundary e.g. metal foil:

- Image charge is created by electric field
- Dipole type field pattern
- Field distribution depends on velocity  $\beta$  and Lorentz factor  $\gamma$  due to relativistic trans. field increase
- Penetration of charge through surface within t < 10 fs: sudden change of source distribution</p>
- > Emission of radiation with dipole characteristic



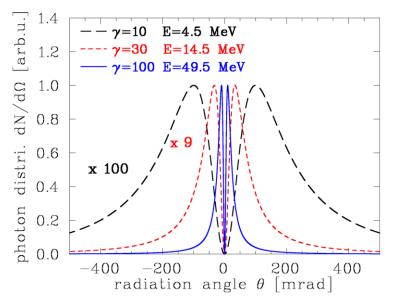
sudden change charge distribution rearrangement of sources ⇔ radiation

Other physical interpretation: Impedance mismatch at boundary leads to radiation



#### **Optical Transition Radiation OTR can be described in classical physics:**

Approximated formula for normal incidence & in-plane polarization:

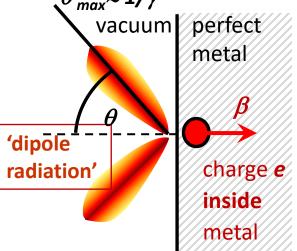


Angular distribution of radiation in optical spectrum:

- Lope emission pattern depends on velocity or Lorentz factor  $\gamma$
- $\blacktriangleright$  Peak at angle  $\theta \approx 1/\gamma$
- Emitted energy i.e. amount of photons scales with  $W \propto \beta^2$
- Broad wave length spectrum (i.e. no dependence on  $\omega$ )
- $\rightarrow$  Suited for high energy electrons

 $\frac{d^2 W}{d\theta \, d\omega} \approx \frac{2e^2\beta^2}{\pi \, c} \cdot \frac{\sin^2 \theta \cdot \cos^2 \theta}{\left(1 - \beta^2 \cos^2 \theta\right)^2}$  $\omega$ : frequency of wave  $\theta_{max} \approx 1/\gamma$ vacuum perfect

W: radiated energy



sudden change charge distribution rearrangement of sources ⇔ radiation

# **Technical Realization of Optical Transition Radiation OTR**

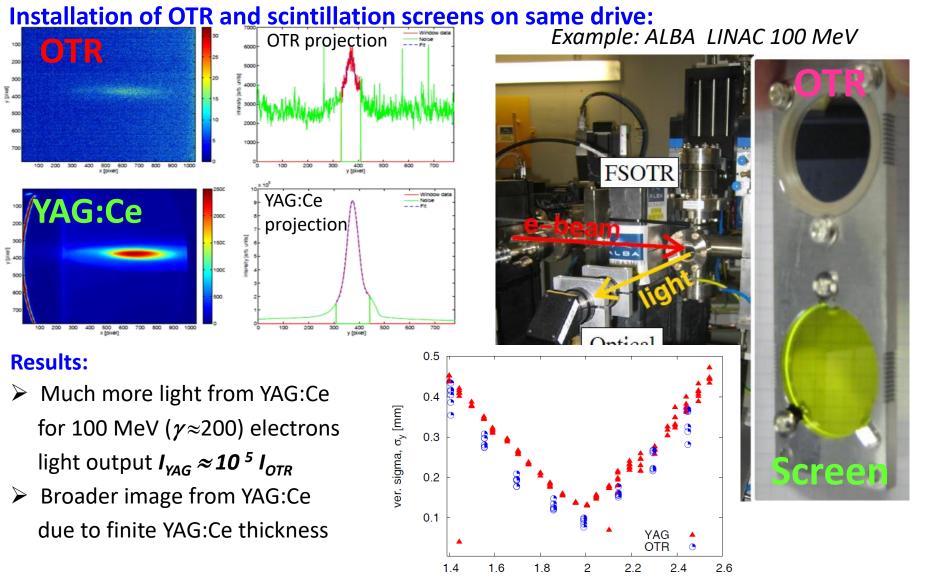


#### **OTR is emitted by charged particle passage through a material boundary.** Photon distribution: $\frac{dN_{photon}}{d\Omega} = N_{beam} \cdot \frac{2e^2\beta^2}{\pi c} \cdot \log\left(\frac{\lambda_{begin}}{\lambda_{end}}\right) \cdot \frac{\theta^2}{\left(\nu^{-2} + \theta^2\right)^2}$ within a solid angle $d\Omega$ and Wavelength interval $\lambda_{begin}$ to $\lambda_{end}$ $\blacktriangleright$ Detection: Optical 400 nm < $\lambda$ < 800 nm mirror $\triangleright$ Larger signal for relativistic beam $\gamma \gg 1$ lens + filter sensitive $\blacktriangleright$ Low divergence for $\gamma \gg 1 \Longrightarrow$ large signal θ window CCD camera $\Rightarrow$ Well suited for e<sup>-</sup> beams $\Rightarrow$ p-beam used for $E_{kin} \gtrsim 10 \text{ GeV} \Leftrightarrow \gamma \gtrsim 10$ beam pipe radiation cone beam OTR screen Insertion of thin Al-foil under 45°

Observation of low light by CCD.

# **Optical Transition Radiation compared to Scintillation Screen**





Courtesy of U. Iriso et al., DIPAC'09

quad current, iq [A]

## **Comparison between Scintillation Screens and OTR**



Quantity	OTR screen	Scintillation screen
Physics basis	Electrodynamic process → intensity linear to # photons, high radiation hardness	Complex <b>atomic</b> process → saturation possible, Possibility: low radiation hardness



Quantity	OTR screen	Scintillation screen
Physics basis	Electrodynamic process → intensity linear to # photons, high radiation hardness	Complex <b>atomic</b> process → saturation possible, Possibility: low radiation hardness
Target property	Thin foil Al or Al on Mylar, down to 0.25 µm thickness → minimizes beam scattering	Thickness ≈ <b>1 mm</b> inorganic, fragile material, not always radiation hard
Signal strength	<b>Low</b> number of photons $\rightarrow$ expensive image intensified cam.	Large number of photons $\rightarrow$ simple camera sufficient
Photon distribution	<b>Complex</b> angular distribution $\rightarrow$ resolution limited	<b>Isotropic</b> photon distribution $\rightarrow$ simple interpretation
Application	<b>Large <math>\gamma</math></b> needed $\rightarrow$ e <sup>-</sup> -beam with $E_{kin} > 100$ MeV, proton-beam with $E_{kin} > 100$ GeV	For <b>all beams</b>

**Remark:** OTR is **not** suited for LINAC-FEL due to **coherent** light emission (not covered here) but scintillation screens can be used.

# **Outline:**

Scintillation screens:

emission of light, universal usage, limited dynamic range

Optical Transition Radiation:

light emission due to crossing material boundary, mainly for relativistic beams

SEM-Grid:

## emission of electrons, workhorse, limited resolution

- Wire scanner
- Ionization Profile Monitor
- Synchrotron Light Monitors
- Summary



# **Secondary Electron Emission by Ion Impact**



#### **Energy loss of ions in metals close to a surface:**

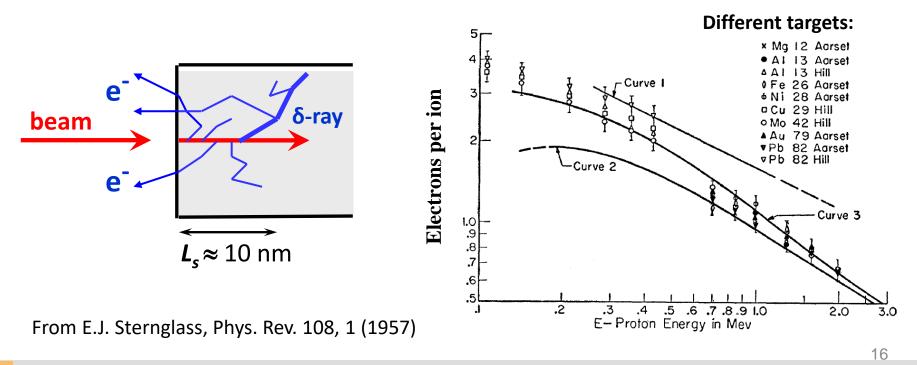
Closed collision with large energy transfer:  $\rightarrow$  fast e<sup>-</sup> with  $E_{kin} >> 100 \text{ eV}$ 

Distant collision with low energy transfer :  $\rightarrow$  slow e<sup>-</sup> with  $E_{kin} \leq 10 \text{ eV}$ 

- $\rightarrow$  'diffusion' & scattering with other e<sup>-</sup>: scattering length  $L_s \approx 1 10$  nm
- $\rightarrow$  at surface  $\approx$  90 % probability for escape

Secondary **electron yield** and energy distribution comparable for all metals!

 $\Rightarrow$  **Y** = const. \* dE/dx (Sternglass formula)

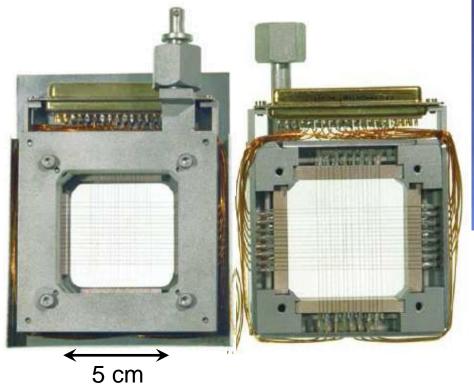


## **Secondary Electron Emission Grids = SEM-Grid**

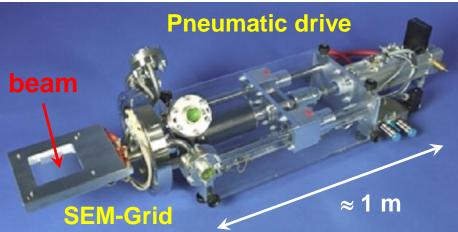


#### **Beam surface interaction**: $e^-$ emission $\rightarrow$ measurement of current.

Example: 15 wire spaced by 1.5 mm:



SEM-Grid drive on  $\varnothing$  200 mm flange:

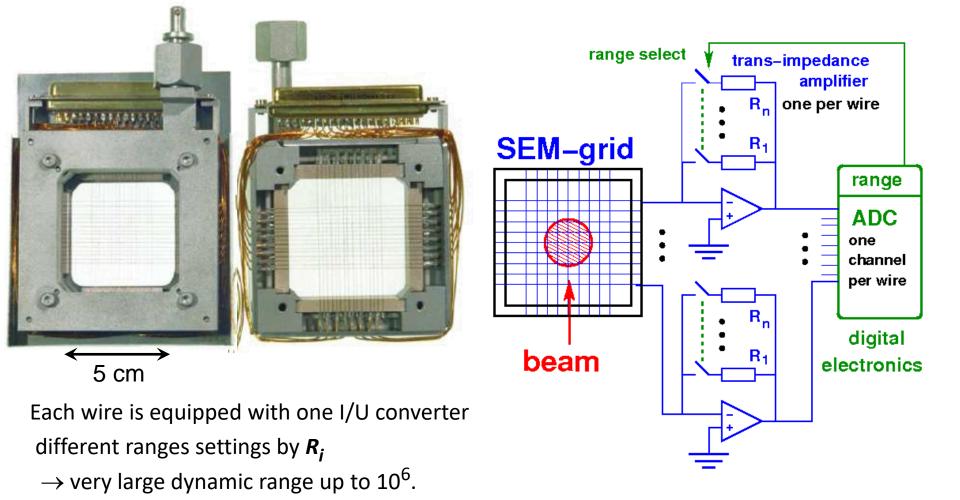


Parameter	Typ. value
# wires per plane	10100
Active area	(520 cm) <sup>2</sup>
Wire $\varnothing$	25100 μm
Spacing	0.32 mm
Material	e.g. W or Carbon
Max. beam power	1 W/mm



#### **Beam surface interaction**: $e^-$ emission $\rightarrow$ measurement of current.

Example: 15 wire spaced by 1.5 mm:

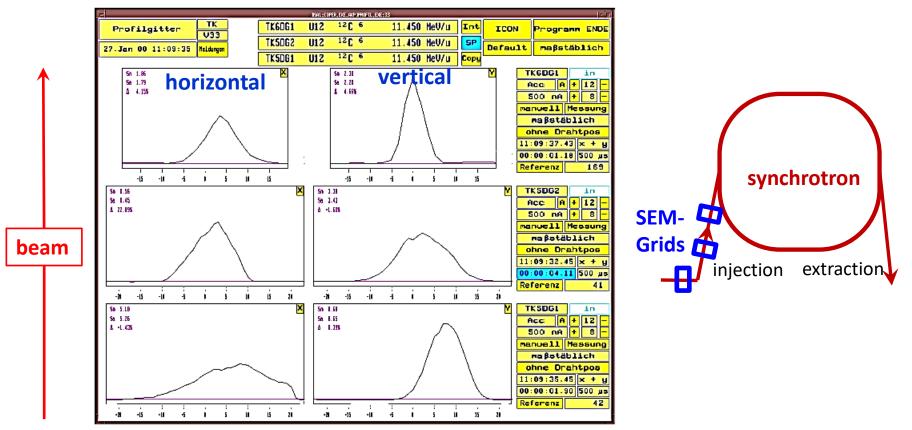


# **Example of Profile Measurement with SEM-Grids**



Even for low energies, several SEM-Grid can be used due to the  $\approx$  80 % transmission  $\Rightarrow$  frequently used instrument beam optimization: setting of quadrupoles, energy....

Example: C<sup>6+</sup> beam of 11.4 MeV/u at different locations at GSI-LINAC



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emission of electrons, workhorse, limited resolution

Wire scanner:

emission of electrons, workhorse, scanning method

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# **Slow, linear Wire Scanner**



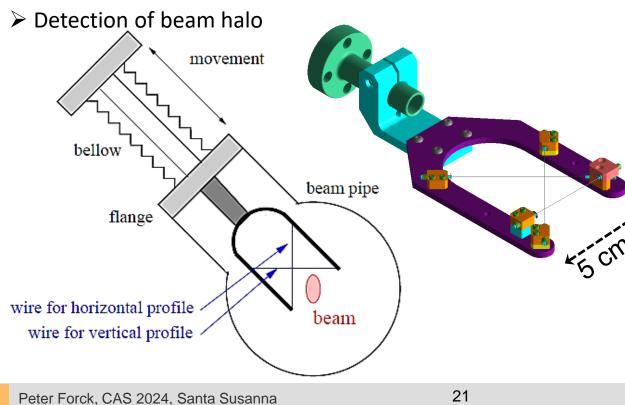
#### Idea: One wire is scanned through the beam!

Wire diameter 100  $\mu$ m <  $d_{wire}$  < 10  $\mu$ m

#### Slow, linear scanner are used for:

Low energy protons

→ High resolution measurements for e<sup>-</sup> beam by de-convolution  $\sigma_{beam}^2 = \sigma_{meas}^2 + r_{wire}^2$  $\Rightarrow$  resolution down to 1 µm range can be reached



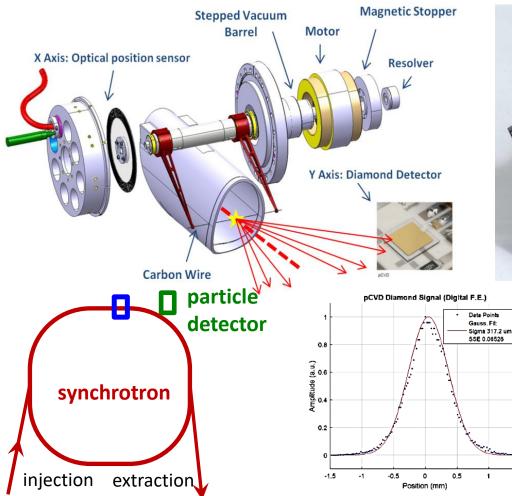
#### Example: Wires scanner at CERB LINAC4

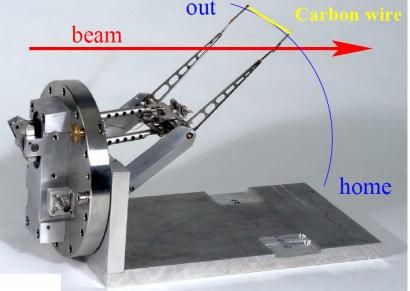
Be



#### In a synchrotron <u>one</u> wire is scanned though the beam as fast as possible.

Fast pendulum scanner for synchrotrons; sometimes it is called 'flying wire':





From <u>https://twiki.cern.ch/twiki/</u> bin/viewauth/BWSUpgrade/

1.5

# **Usage of Flying Wire Scanners**



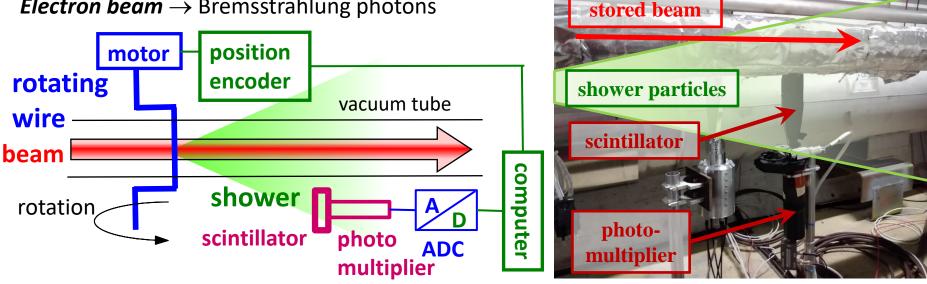
*Material:* Carbon or SiC  $\rightarrow$  low Z-material for low energy loss and high temperature. *Thickness*: Down to 10  $\mu$ m  $\rightarrow$  high resolution.

Detection: High energy secondary particles with a detector like a beam loss monitor

#### Secondary particles:

**Proton beam**  $\rightarrow$  hadrons shower ( $\pi$ , n, p...) **Electron beam**  $\rightarrow$  Bremsstrahlung photons

#### Detector in LHC:



# **Usage of Flying Wire Scanners**

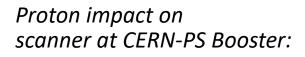
**Proton beam**  $\rightarrow$  hadrons shower ( $\pi$ , n, p...)

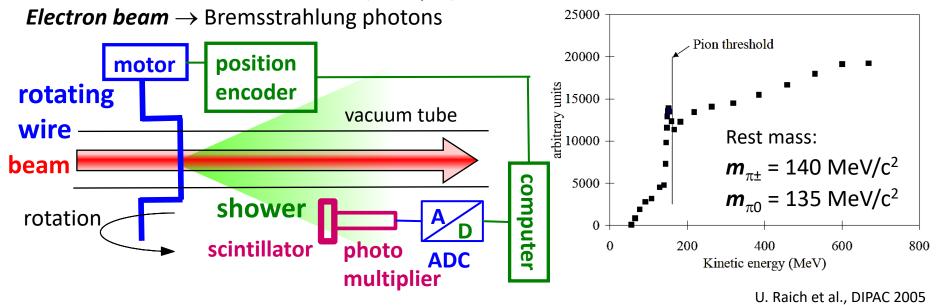


*Material:* Carbon or SiC  $\rightarrow$  low Z-material for low energy loss and high temperature. *Thickness*: Down to 10  $\mu$ m  $\rightarrow$  high resolution.

Detection: High energy secondary particles with a detector like a beam loss monitor

#### Secondary particles:





#### Kinematics of flying wire:

Velocity during passage typi. 10 m/s = 36 km/h & typical beam size  $\varnothing$  10 mm

- $\Rightarrow$  time for traversing the beam  $t \approx 1$  ms
- Challenges: Wire stability for fast movement with high acceleration



Quantity	Grid	Linear scanner
Time resolution	Measurement at a <b>single</b> <b>moment</b> in time	Scanning method $\rightarrow$ fast variations can't be monitored



Quantity	Grid	Linear scanner
Time resolution	Measurement at a <b>single</b> <b>moment</b> in time	Scanning method $\rightarrow$ fast variations can't be monitored
Spatial resolution	Fixed by the wire <b>distance</b> (typically 1 mm)	Fixed by the wire <b>thickness</b> (typically 0.1 mm)
Electronics	<b>Multi-channel</b> , one for each wire $\rightarrow$ expensive	Single channel $\rightarrow$ cheap
Mechanics	<b>Pneumatics</b> for in $\leftrightarrow$ out $\rightarrow$ cheap	Stepping motor required → expensive
Application	Required for <b>pulsed</b> beams	Required for <b>small</b> beams
	However, related to tradition at laboratory	

#### Flying wire scanner:

Grid: Not adequate at synchrotrons for stored beam parametersScanner: At high energy synchrotrons: flying wire scanners are nearly non-destructive

# **Outline**:

Scintillation screens:

emission of light, universal usage, limited dynamic range

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light emission due to crossing material boundary, mainly for relativistic beams

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> SEM-Grid:

emission of electrons, workhorse, limited resolution

> Wire scanner:

emission of electrons, workhorse, scanning method

Ionization Profile Monitor:

secondary particle detection from interaction beam-residual gas

- Synchrotron Light Monitors
- > Summary





# Interaction between Residual Gas and the Beams



## **Physics:** Energy loss of ions in gas *dE/dx*

 $\Rightarrow$  Profile determination from residual gas

#### Ionization:

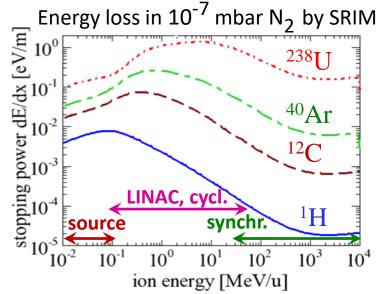
in average roughly  $\approx$  100 eV/ionization

> Excitation followed by photon emission: in average roughly  $\approx$  300 eV/event e.g. N<sub>2</sub> However, depends strongly on gas molecule

#### Typical vacuum pressure & ideal gas law $pV = nk_BT$ Transfer line:

N<sub>2</sub> pressure  $p \approx 10^{-8} \dots 10^{-6}$  mbar ⇔ density  $\rho_{gas} \approx 3 \cdot 10^{8} \dots 3 \cdot 10^{10} \text{ cm}^{-3}$ Synchrotron: H<sub>2</sub> pressure  $p \approx 10^{-11} \dots 10^{-9}$  mbar ⇔ density  $\rho_{gas} \approx 3 \cdot 10^{5} \dots 3 \cdot 10^{7}$  cm<sup>-3</sup>

# beam pipe res. gas atom e<sup>-</sup> o e<sup>-</sup> o e<sup>-</sup> ionization e<sup>-</sup> o e<sup>-</sup> beam e<sup>-</sup> excitation e<sup>-</sup> o e<sup>-</sup>



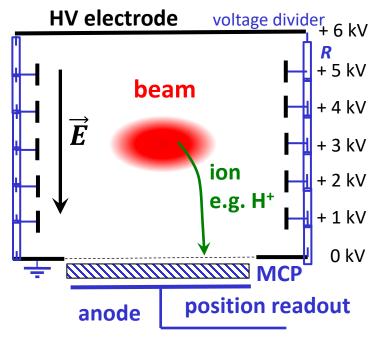
# **Beam density for comparison:** Proton accelerator at 1 GeV, 100 mA, trans. width $\sigma = 300 \ \mu m$ , coasting beam $\Rightarrow$ density $\rho_{beam} \approx 10^8 \ \text{cm}^{-3} \rightarrow \text{beam density might be lower the vacuum density!}$

# **Ionization Profile Monitor at GSI Synchrotron**

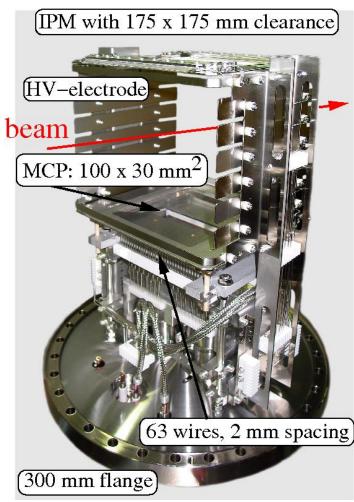


#### Non-destructive device for proton synchrotron:

- > Beam ionizes the residual gas by electronic stopping
- $\succ$  Gas ions or e<sup>-</sup> accelerated by E -field ≈1 kV/cm
- Spatial resolved single particle detection



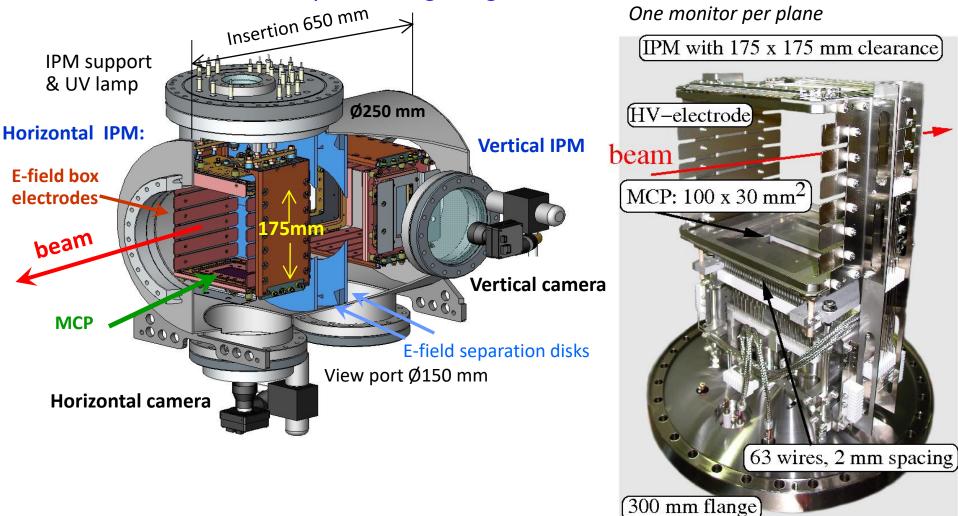
*Realization at GSI synchrotron: One monitor per plane* 



## **Ionization Profile Monitor Realization**



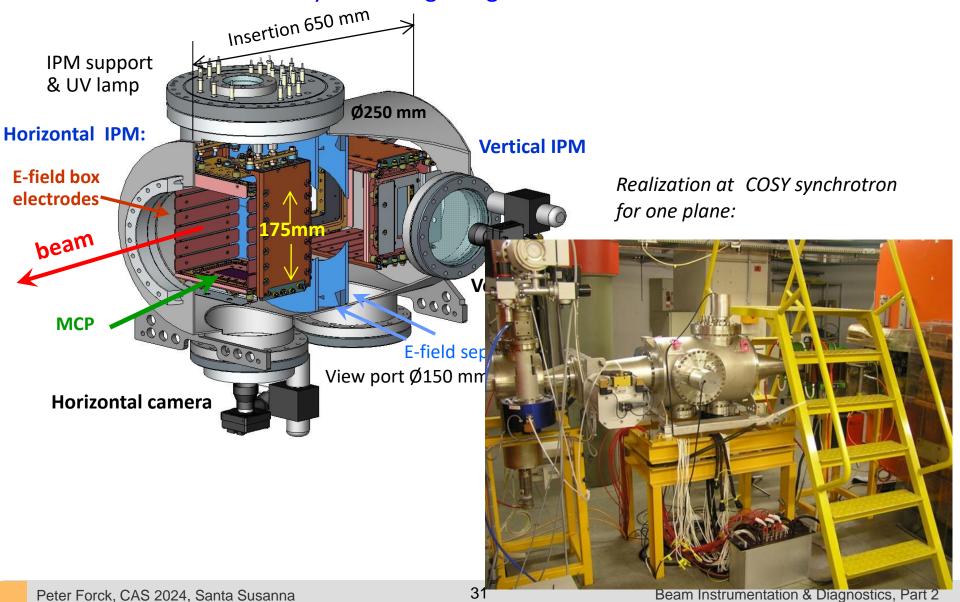
The realization for the heavy ion storage ring ESR at GSI: Realization at GSI synchrotron:



## **Ionization Profile Monitor Realization**



## The realization for the heavy ion storage ring ESR at GSI:



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emission of electrons, workhorse, limited resolution

> Wire scanner:

emission of electrons, workhorse, scanning method

Ionization Profile Monitor:

secondary particle detection from interaction beam-residual gas

Synchrotron Light Monitors:

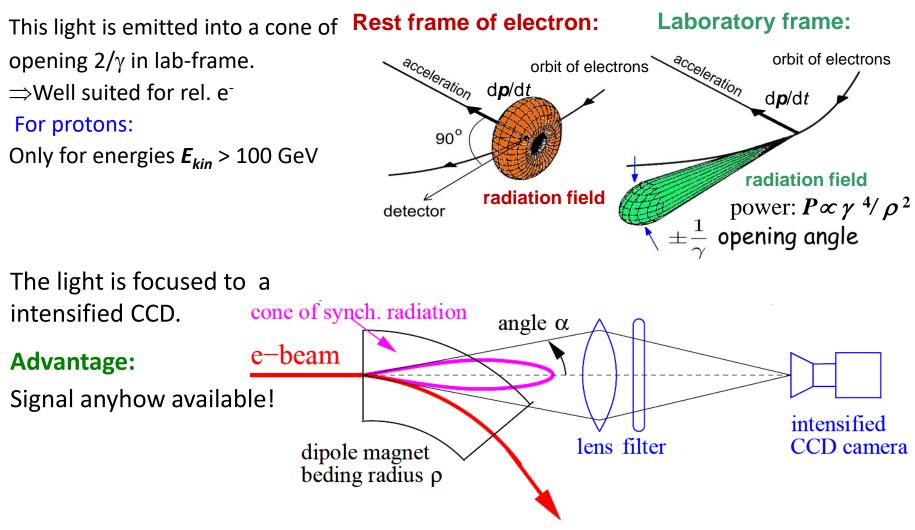
## photon detection of emitted synchrotron light in optical and X-ray range

> Summary





# An electron bent (i.e. accelerated) by a dipole magnet emit synchrotron light see lecture 'Electron Beam Dynamics' by Lenny Rivkin



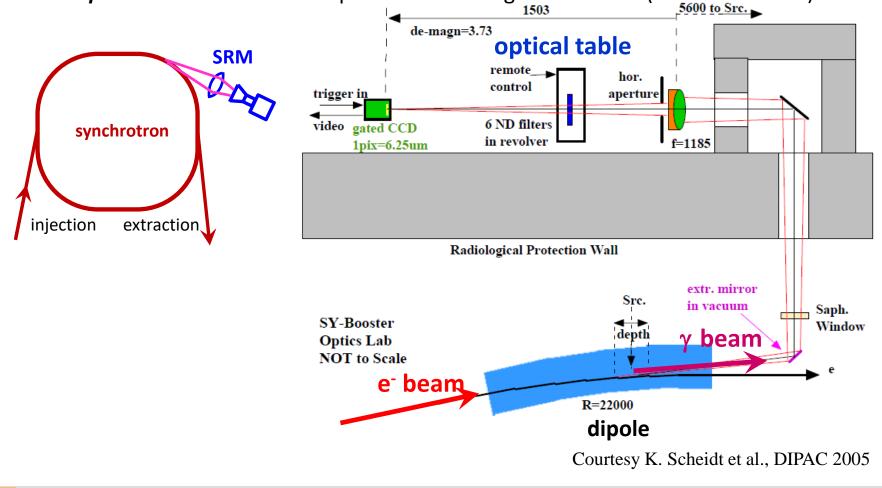
# **Realization of a Synchrotron Radiation Monitor**



Extracting out of the beam's plane by a (cooled) mirror

- ightarrow Focus to a slit + wavelength filter for optical wavelength
- ightarrow Image intensified CCD camera

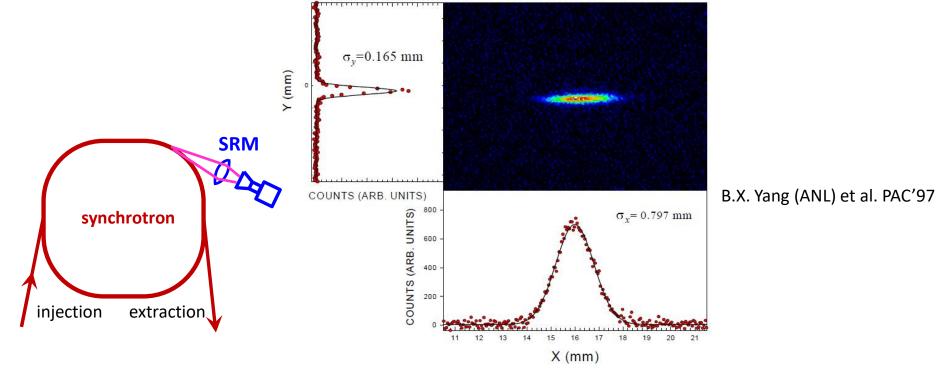
**Example:** ESRF monitor from dipole with bending radius 22 m (blue or near UV)



## **Result from a Synchrotron Light Monitor**







Advantage: Direct measurement of 2-dim distribution, good optics for visible light Realization: Optics outside of vacuum pipe

**Disadvantage:** Resolution limited by the diffraction due to finite apertures in the optics.

# 'Adiabatic Damping' for an Electron Beam



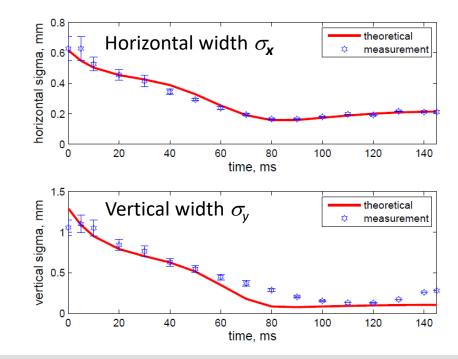
**Example:** Booster at the light source ALBA acceleration from  $0.1 \rightarrow 3$  GeV within 130 ms Profiles from synchrotron radiation monitor: The beam emittance in influenced by:

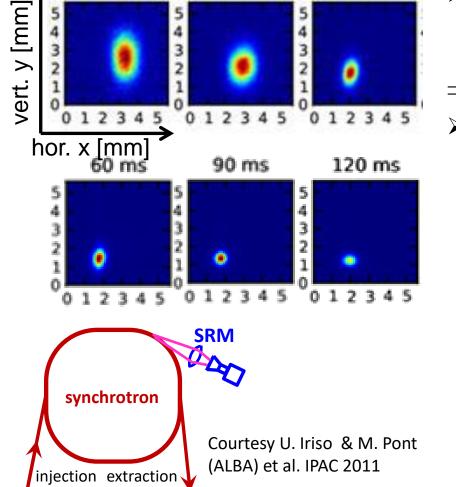
30 ms

- Adiabatic damping
- ► Longitudinal momentum contribution via dispersion $D(s) \Rightarrow \Delta x_D(s) = D(s) \cdot \frac{\Delta p}{p}$

$$\Rightarrow$$
 total width  $\sigma_{tot}(s) = \sqrt{\epsilon\beta(s) + \left(D(s) \cdot \frac{\Delta p}{p}\right)^2}$ 

Quantum fluctuation due to light emission



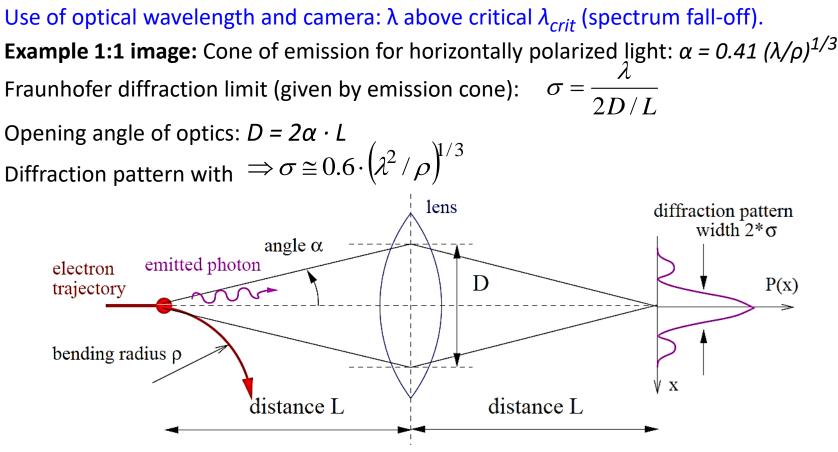


10 ms

Peter Forck, CAS 2024, Santa Susanna

0 ms

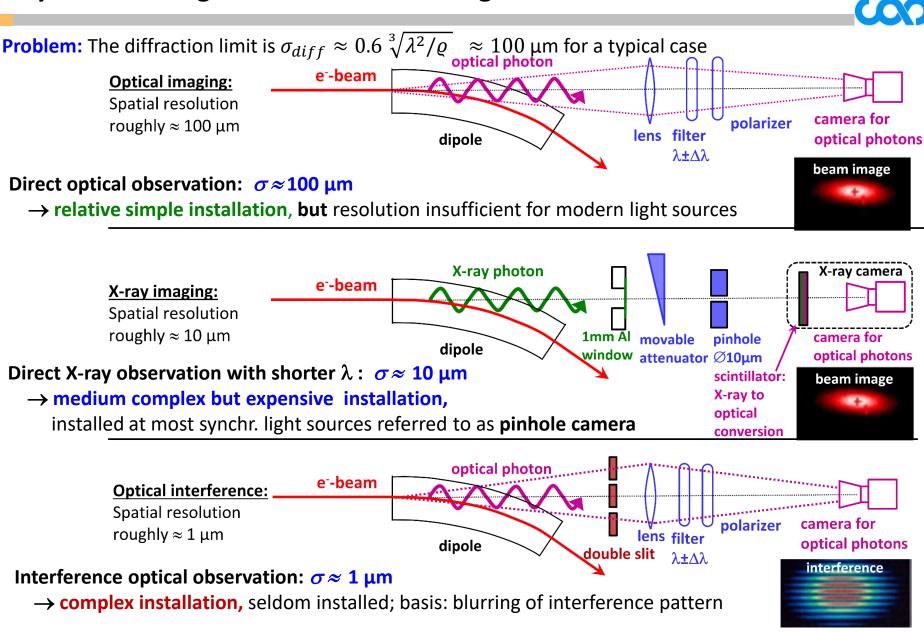




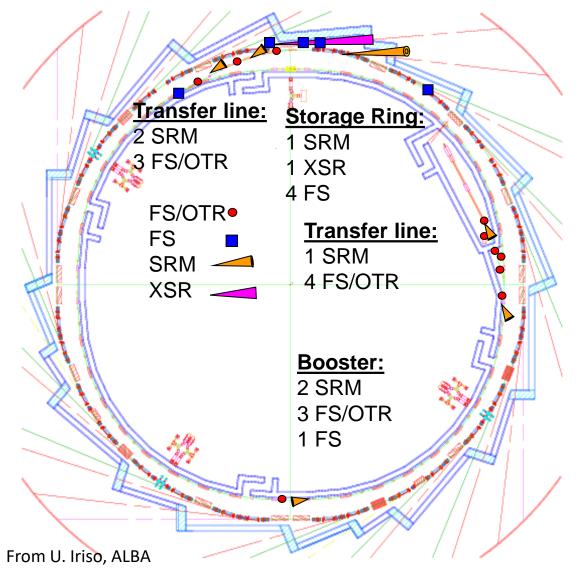
#### A good resolution for:

- $\succ$  large dipole bending radius  $\rho$ , **but** fixed by the accelerator
- > short wavelength, **but** good optics only for  $\lambda$  > 300 nm

## Synchrotron Light Monitor overcoming Diffraction Limit



Appendix: The Synchrotron Light Facility ALBA: Profile Measurement



#### Transverse profile:

- Many location in transport line
- Single location in ring
- Different devices used

#### Abbreviation:

FS: Fluorescence Screen
OTR: Optical Trans. Rad. Screen
FS & OTR are destructive
SRM: Synchr. Radiation Monitor
XSR: X-ray pin hole camera
both non-destructive



## *Different techniques are suited for different beam parameters:*

- e<sup>-</sup>-beam: typically Ø 0.01 to 3 mm, protons: typically Ø 1 to 30 mm
- Intercepting ↔ non-intercepting methods

## Direct observation of electrodynamics processes:

- > Optical synchrotron radiation monitor: non-destructive, for e<sup>-</sup>-beams, complex, limited res.
- ➤ X-ray synchrotron radiation monitor: non-destructive, for e<sup>-</sup>-beams, very complex
- > OTR screen: nearly non-destructive, large relativistic  $\gamma$  needed, e<sup>-</sup>-beams mainly

#### Detection of secondary photons, electrons or ions:

- Scintillation screen: destructive, large signal, simple setup, all beams
- Ionization profile monitor: non-destructive, expensive, limited resolution, for protons

### Wire based electronic methods:

- SEM-grid: partly destructive, large signal and dynamic range, limited resolution
- Wire scanner: partly destructive, large signal and dynamics, high resolution, slow scan.

# 

## **Outline of this lecture:**

- Transverse profile techniques
- Emittance determination at transfer lines
- Diagnostics for bunch shape determination



## The emittance characterizes the whole beam quality, assuming linear behavior as described by second order differential equation. It is defined within the phase space as: $\varepsilon_x = \frac{1}{\pi} \int_A dx dx'$

### The measurement is based on determination of:

**Either** profile width  $\sigma_x$  and angular width  $\sigma_x'$  at one location **Or** profile width  $\sigma_x$  at different locations and linear transformations.

#### Different devices are used at transfer lines:

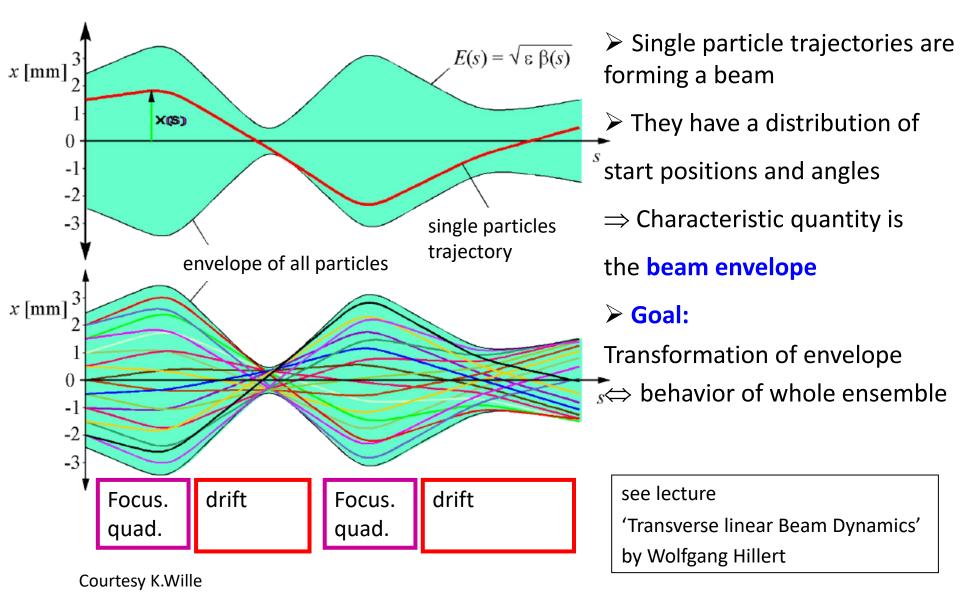
- > Lower energies  $E_{kin}$  < 100 MeV/u: slit-grid device, pepper-pot (suited in case of non-linear forces).
- All beams: Quadrupole variation method using linear transformations (not well suited in the presence of non-linear forces)

#### Synchrotron: lattice functions results in stability criterion

 $\Rightarrow \text{ beam width delivers emittance: } \varepsilon_x = \frac{1}{\beta_x(s)} \left[ \sigma_x^2 - \left( D(s) \frac{\Delta p}{p} \right) \right] \text{ and } \varepsilon_y = \frac{\sigma_y^2}{\beta_y(s)}$ 

## **Trajectory and Characterization of many Particles**





## **Definition of Coordinates and basic Equations**

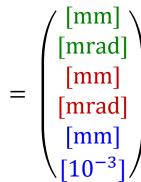


The basic vector is 6 dimensional:

al: 
$$\begin{pmatrix} x \\ x' \\ y \\ y' \\ l \\ \delta \end{pmatrix}$$
 =

(hori. spatial deviation horizontal divergence vert. spatial deviation vertical divergence long. deviation momentum deviation

Beam width for



The transformation of a single particle from a location  $s_0$  to  $s_1$  is given by the Transfer Matrix R:  $\vec{x}(s_1) = \mathbf{R}(s) \cdot \vec{x}(s_0)$ The transformation of a the envelope from a location  $s_0$  to  $s_1$  is given by the Beam Matrix  $\sigma$ :  $\sigma(s_1) = \mathbf{R}(s) \cdot \sigma(s_0) \cdot \mathbf{R}^{\mathrm{T}}(s)$ 

6-dim Beam Matrix with <u>decoupled</u> hor., vert. and long. plane:

$$\sigma = \begin{pmatrix} \sigma_{11} & \sigma_{12} & 0 & 0 & 0 & 0 \\ \sigma_{12} & \sigma_{22} & 0 & 0 & 0 & 0 \\ 0 & 0 & \sigma_{33} & \sigma_{34} & 0 & 0 \\ 0 & 0 & \sigma_{34} & \sigma_{44} & 0 & 0 \\ 0 & 0 & 0 & 0 & \sigma_{55} & \sigma_{56} \\ 0 & 0 & 0 & 0 & \sigma_{56} & \sigma_{66} \end{pmatrix}$$
horizontal coordinates: beam matrix: beam matrix:  $x_{rms} = \sqrt{\sigma_{11}} \quad \sigma_{11} = \langle x^2 \rangle$   
longitudinal hor.-long. coupling  $y_{rms} = \sqrt{\sigma_{33}} \quad \sigma_{12} = \langle x x' \rangle$   
 $\rightarrow 9 \text{ values} \quad \downarrow_{rms} = \sqrt{\sigma_{55}} \quad \sigma_{22} = \langle x'^2 \rangle$ 



## **Outline:**

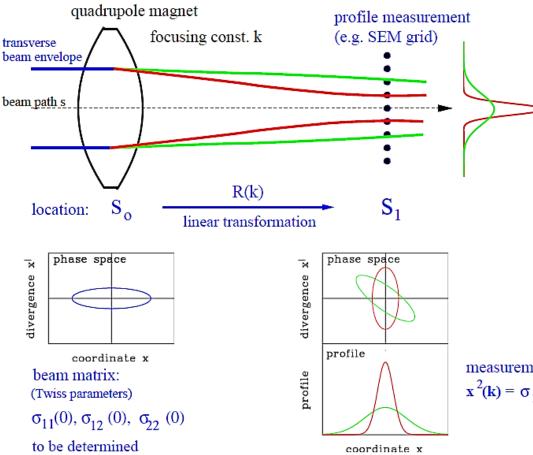
- > Definition and some properties of transverse emittance
- Quadrupole strength variation and position measurement

emittance from several profile measurement and beam optical calculation

Slit-Grid device: scanning method



From a profile determination, the emittance can be calculated via linear transformation, if a well known and constant distribution (e.g. Gaussian) is assumed.



Measurement of beam width

$$x^2_{max} = \sigma_{11}(s_1, k)$$

- matrix **R**(*k*) describes the focusing.
- With the drift matrix the transfer is  $\mathbf{R}(k_i) = \mathbf{R}_{\text{drift}} \cdot \mathbf{R}_{\text{focus}}(k_i)$
- Transformation of the beam matrix

 $\sigma(s_1,k_i) = \mathbf{R}(k_i) \cdot \sigma(s_0) \cdot \mathbf{R}^{\mathsf{T}}(k_i)$ 

Task: Calculation of matrix  $\sigma(s_0)$ 

at entrance s<sub>o</sub>, i.e. three elements

measurement:

 $x^{2}(k) = \sigma_{11}(1,k)$ 

see lecture 'Linear Imperfections' by Volker Ziemann

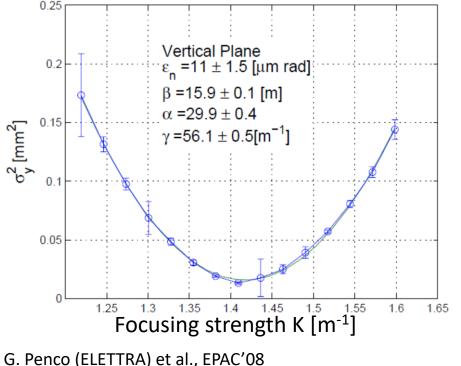


Using the 'thin lens approximation' i.e. the quadrupole has a focal length of *f*:

$$\mathbf{R}_{focus}(K) = \begin{pmatrix} \mathbf{1} & \mathbf{0} \\ -\mathbf{1}/f & \mathbf{1} \end{pmatrix} \equiv \begin{pmatrix} \mathbf{1} & \mathbf{0} \\ K & \mathbf{1} \end{pmatrix} \implies \mathbf{R}(L, K) = \mathbf{R}_{drift}(L) \cdot \mathbf{R}_{focus}(K) = \begin{pmatrix} \mathbf{1} + LK & L \\ K & \mathbf{1} \end{pmatrix}$$

Measurement of matrix-element  $\sigma_{11}(s_1, K)$  from matrices  $\sigma(s_1, K_i) = \mathbf{R}(K_i) \cdot \sigma(s_0) \cdot \mathbf{R}^{\mathsf{T}}(K_i)$ **Example:** Square of the beam width at

ELETTRA 100 MeV e<sup>-</sup> Linac, YAG:Ce:



For completeness: The relevant formulas  $\sigma_{11}(1, K) = L^2 \sigma_{11}(0) \cdot K^2$ 

$$+2 \cdot (L\sigma_{11}(0) + L^2\sigma_{12}(0)) \cdot K$$
$$+L^2\sigma_{22}(0) + \sigma_{11}(0)$$
$$\equiv a \cdot K^2 - 2ab \cdot K + ab^2 + c$$
$$= a \cdot (K - b)^2 + c$$

A fit delivers the beam matrix elements  $\sigma_{ij}(s_0)$ 

#### **Assumptions:**

- 'Regular' phase space distribution
- Well aligned beam, no steering
- > No emittance blow-up due to space charge

#### **Improved methods:**

Based on e.g. tomographic reconstruction



## **Outline:**

- Definition and some properties of transverse emittance
- Quadrupole strength variation and position measurement emittance from several profile measurement and beam optical calculation
- Slit-Grid device: scanning method

scanning slit  $\rightarrow$  beam position & grid  $\rightarrow$  angular distribution

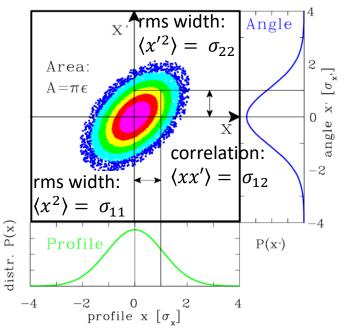


#### The beam distribution can be non-Gaussian, e.g. at:

- Beams behind ion source
- Space charged dominated beams at LINAC & synchrotron
- Cooled beams in storage rings

Generally: Emittance by 2<sup>nd</sup> statistical moments of 2-dim distribution:

Beam matrix:  $\boldsymbol{\sigma} = \begin{pmatrix} \langle x^2 \rangle & \langle xx' \rangle \\ \langle xx' \rangle & \langle x'^2 \rangle \end{pmatrix}$ Emittance:  $\varepsilon_{rms} = \sqrt{\det \boldsymbol{\sigma}}$   $\varepsilon_{rms} = \sqrt{\langle x^2 \rangle \langle x'^2 \rangle - \langle xx' \rangle^2}$ Variances Covariance i.e. correlation It describes the value for 1 standard derivation.



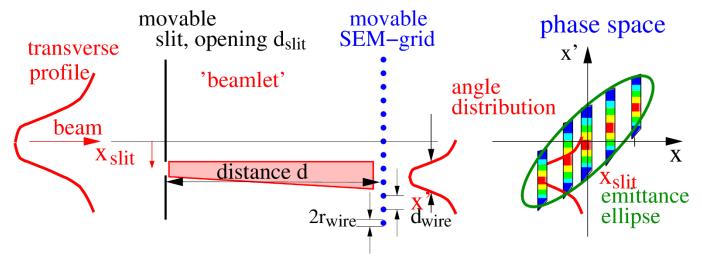


Slit-Grid: Direct determination of position and angle distribution.

Used for protons with  $E_{kin} < 100 \text{ MeV/u} \Rightarrow \text{range } R < 1 \text{ cm}$ .

#### Hardware

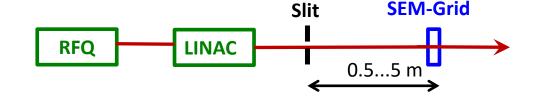




*Slit*: position *P(x)* with typical width: 0.1 to 0.5 mm

*Distance:* typ. 0.5 to 5 m (depending on beam energy 0.1 ... 100 MeV)

**SEM-Grid:** angle distribution **P(x')** 



## **Display of Measurement Results**



The distribution is depicted as a function of position [mm] & angle [mrad] The distribution can be visualized by

- Mountain plot
- Contour plot

**Calc. of 2<sup>nd</sup> moments**  $\langle x^2 \rangle$ ,  $\langle x'^2 \rangle$  &  $\langle xx' \rangle$ 

Emittance value  $\boldsymbol{\varepsilon}_{rms}$  from

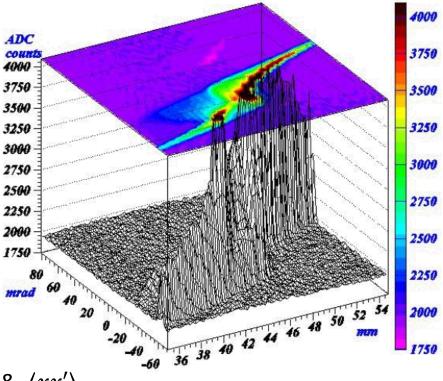
$$\boldsymbol{\varepsilon_{rms}} = \sqrt{\langle x^2 \rangle \cdot \langle x'^2 \rangle - \langle xx' \rangle^2}$$

**Problems:** 

- Finite binning results in limited resolution
- ▶ **Background** → large influence on  $\langle x^2 \rangle$ ,  $\langle x'^2 \rangle$  &  $\langle xx' \rangle$
- Or fit of distribution with an ellipse
- $\Rightarrow$  Effective emittance only

**Remark**: Behind a ion source the beam might be non-Gaussian due to plasma density and aberration at quadrupoles

See lecture 'Sources' by dan Faircloth



**Beam**: Ar<sup>4+</sup>, 60 keV, 15 μA

at Spiral2 Phoenix ECR source.

P. Ausset, DIPAC 2009



## Emittance is the important quantity for comparison to theory.

It includes absolute value (value of  $\boldsymbol{\varepsilon}$ ) & orientation in phase space ( $\sigma_{ii}$  or  $\boldsymbol{\alpha}$ ,  $\boldsymbol{\beta}$  and  $\boldsymbol{\gamma}$ )

three independent values  $\varepsilon_{rms} = \sqrt{\sigma_{11} \cdot \sigma_{22} - \sigma_{12}} \equiv \sqrt{\langle x^2 \rangle \langle x'^2 \rangle} - \langle xx' \rangle^2$ 

assuming **no** coupling between horizontal, vertical and longitudinal planes

## Transfer line, all beams → profile measurement + linear transformation:

Quadrupole variation: one location, different setting of a quadrupole
Assumptions: > well aligned beam, no steering

no emittance blow-up due to space charge

#### Transfer line, low energy beams $\rightarrow$ direct measurement of x- and x'-distribution:

- > *Slit-grid:* movable slit  $\rightarrow x$ -profile, grid  $\rightarrow x'$ -profile
- ▶ Requirement: Beam is stopped in  $\approx$  1cm  $\Leftrightarrow$  protons  $E_{kin} \leq 100$  MeV

**Remark**: Non-linear transformation possible via tomographic reconstruction **Important remark:** For a synchrotron with a *stable beam storage*,

width measurement is sufficient using  $x_{rms} = \sqrt{\varepsilon_{rms} \cdot \beta}$ 



## **Outline of this lecture:**

- Transverse profile techniques
- Emittance determination at transfer lines
- > Diagnostics for bunch shape determination and longitudinal parameters

## **Measurement of longitudinal Parameters**

# GSI

## **Measurement of longitudinal parameter:**

## Bunch length measurement at

- Synchrotron light sources: Streak camera
- Linear light sources: Electro-optical modulator
- > Summary

#### Longitudinal $\leftrightarrow$ transverse correspondences:

position relative to rf

- $\leftrightarrow$  transverse center-of-mass
- bunch structure in time
  - n time  $\leftrightarrow$  transverse profile
- $\succ$  momentum or energy spread  $\leftrightarrow$  transverse divergence
- $\succ$  longitudinal emittance  $\leftrightarrow$  transverse emittance.

## The Bunch Position measured by a Pick-Up

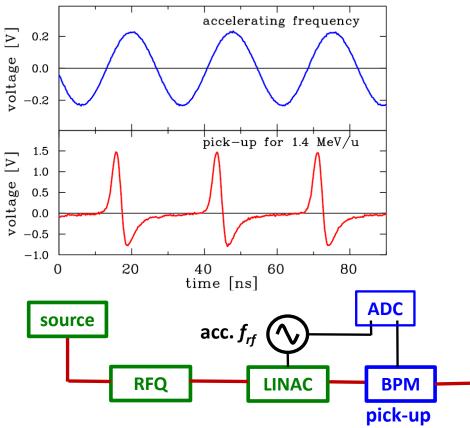


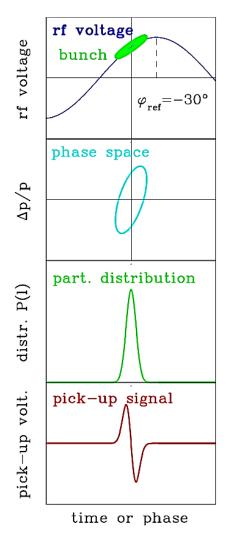
#### The *bunch position* is given relative to the accelerating rf.

e.g.  $\boldsymbol{\varphi_{ref}}$ =-30° inside a rf cavity

must be well aligned for optimal acceleration Transverse correspondence: Beam position

**Example:** Pick-up signal for  $f_{rf}$  = 36 MHz rf at GSI-LINAC:



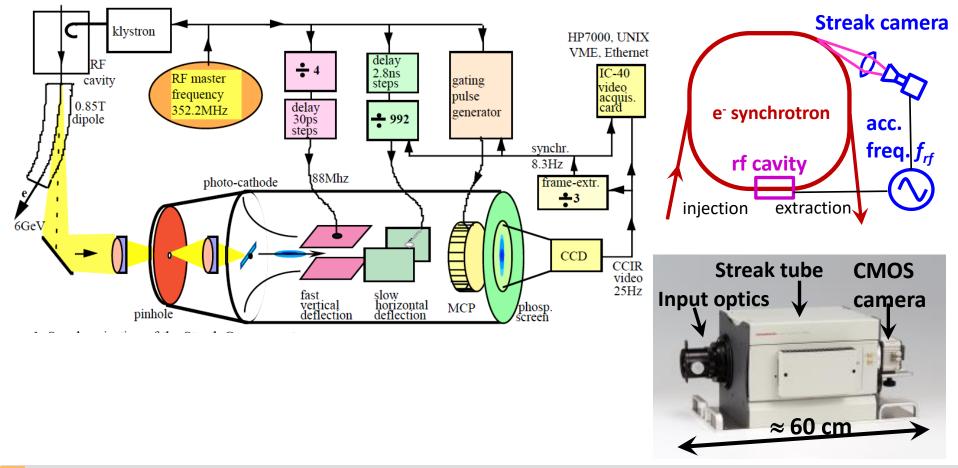




Electron bunches are too short ( $\sigma_t$  < 100 ps) to be covered by the bandwidth of

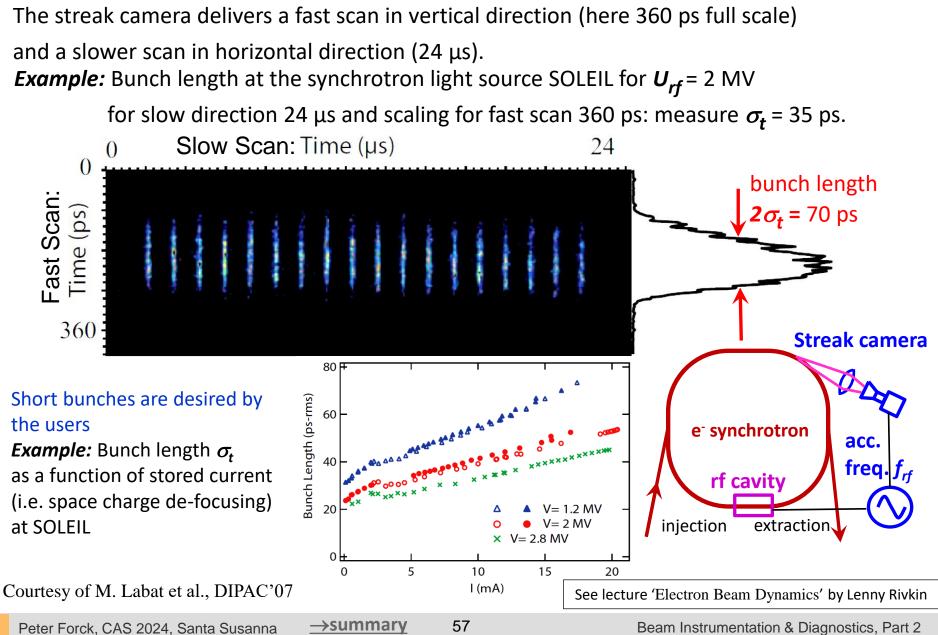
pick-ups ( $f < 3 \text{ GHz} \Leftrightarrow t_{rise} > 100 \text{ ps}$ ) for structure determination.

 $\rightarrow$  Time resolved observation of synchr. light with a streak camera: Resolution  $\approx$  1 ps. Scheme of a streak camera



## **Results of Bunch Length Measurement by a Streak Camera**





## **Measurement of longitudinal Parameters**



## **Measurement of longitudinal parameter:**

### Bunch length measurement at

- Synchrotron light sources: Streak camera
- Linear light sources: Electro-optical modulators
- > Summary

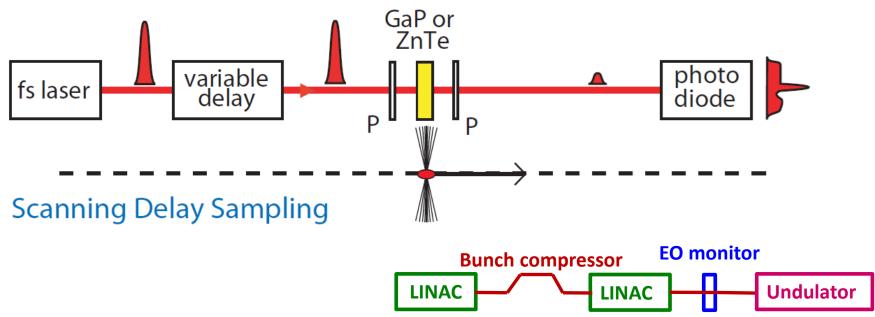
## **Bunch Length Measurement by electro-optical Method**



## For Free Electron Lasers $\rightarrow$ bunch length below 1 ps is achieved

- Below the resolution of streak camera
- $\blacktriangleright$  Short laser pulses with  $t \approx 10 \text{ fs}$  and electro-optical modulator

**Electro optical modulator:** Birefringent, rotation angle depends on external electric field Relativistic electron bunch: transverse ele. field  $E_{\perp,lab} = \gamma E_{\perp,rest}$  carries the time information Scanning of delay between bunch and laser  $\rightarrow$  time profile after several pulses.



Courtesy S.P.Jamison et al., EPAC 2006

See lecture 'Synchrotron light circular machines & FELs' by Eduard Prat

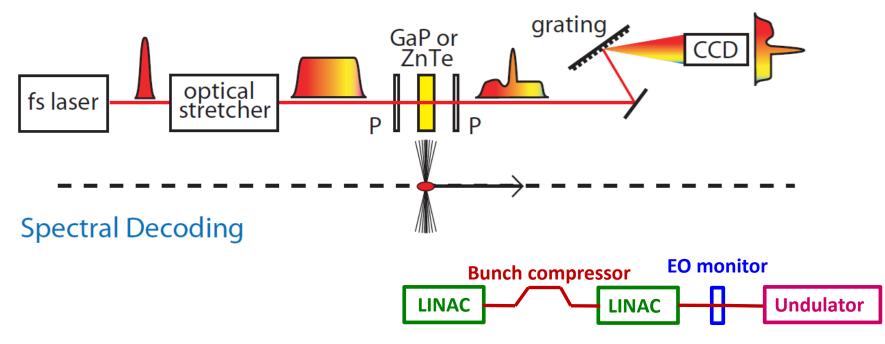


#### For Free Electron Lasers $\rightarrow$ bunch length below 1 ps is achieved

Short laser pulse ⇔ broad frequency spectrum (property of Fourier Transformation)

**Optical stretcher**: Separation of colors by different path length

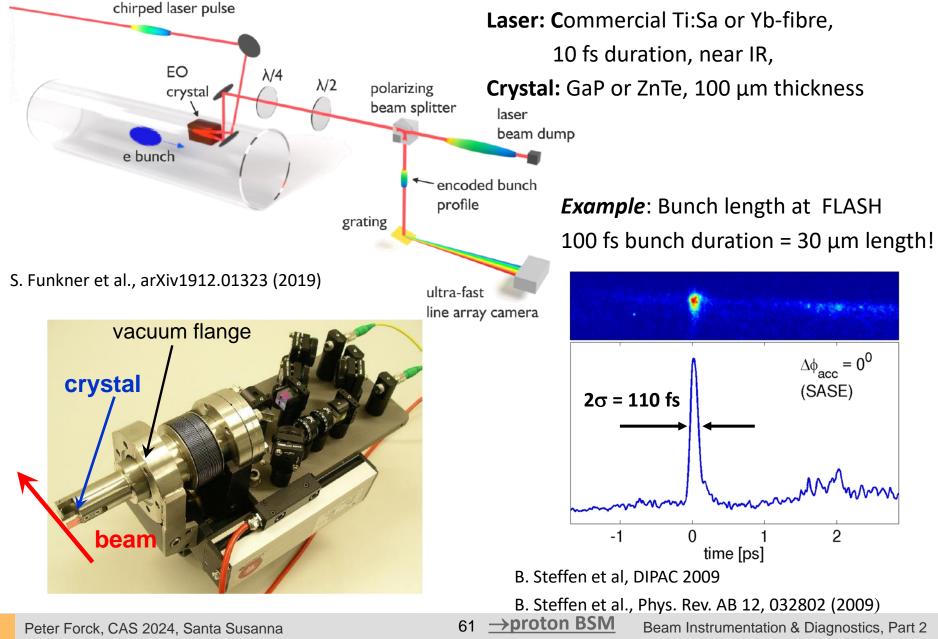
 $\Rightarrow$  different colors at different time  $\Rightarrow$  single-shot observation



Courtesy S.P.Jamison et al., EPAC 2006

## Hardware of a spectral-decoded EOSD Scanning Setup





#### Devices for bunch length at light sources:

#### Streak cameras:

- Time resolved monitoring of synchrotron radiation
  - $\rightarrow$  for relativistic e<sup>-</sup>-beams, 10 ps <  $t_{bunch}$  < 1 ns

Time resolution limit of streak camera  $\approx$  1 ps

#### Laser-based electro-optical modulation:

Electro-optical modulation of short laser pulse

 $\rightarrow$  very high time resolution down to some fs time resolution

Technical complex installation

 $\rightarrow$ BLM





## Diagnostics is the 'sensory organ' for the beam.

It required for operation and development of accelerators

## Several categories of demands leads to different installations:

- Quick, non-destructive measurements leading to a single number or simple plots
- Complex instrumentation used for hard malfunction and accelerator development
- > Automated measurement and control of beam parameters i.e. feedback

The goal and a clear interpretation of the results is a important design criterion.

## **General comments:**

- > Quite different technologies are used, based on various physics processes
- > Accelerator development goes parallel to diagnostics development
- ( $\Rightarrow$  it makes fun as many skills are required).

## Thank you for your attention!



- > H. Schmickler (Ed.) *Beam Instrumentation*, Proc. CERN Accelerator School, Tuusula 2018.
- D. Brandt (Ed.), Beam Diagnostics for Accelerators, Proc. CERN Accelerator School, Dourdan, CERN-2009-005, 2009.
- Proceedings of several CERN Acc. Schools (introduction & advanced level, special topics).
- V. Smaluk, Particle Beam Diagnostics for Accelerators: Instruments and Methods,
   VDM Verlag Dr. Müller, Saarbrücken 2009.
- > P. Strehl, *Beam Instrumentation and Diagnostics*, Springer-Verlag, Berlin 2006.
- M.G. Minty and F. Zimmermann, Measurement and Control of Charged Particle Beams, Springer-Verlag, Berlin 2003.
- S-I. Kurokawa, S.Y. Lee, E. Perevedentev, S. Turner (Eds.), Proceeding of the School on Beam Measurement, Proceedings Montreux, World Scientific Singapore (1999).
- > P. Forck, *Lecture Notes on Beam Instrumentation and Diagnostics*, JUAS School, JUAS Indico web-site.
- > Contributions to conferences, in particular to International Beam Instrumentation Conference IBIC.



## **Backup slides**



Influence of the residual gas ion trajectory by :

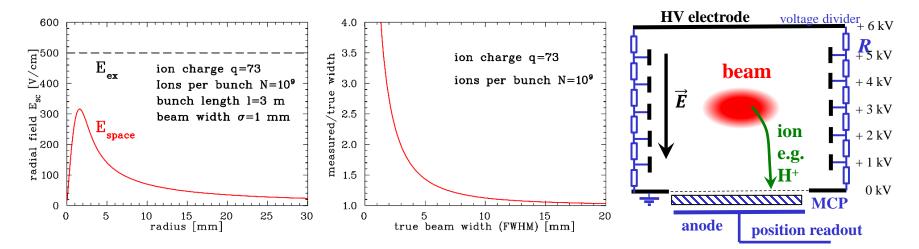
- External electric field E<sub>ex</sub>
- Electric field of the beam's space charge E<sub>space</sub>

e.g. Gaussian density distribution for round beam:  $E_{space}(r) = \frac{1}{2\pi\varepsilon_0} \cdot \frac{qeN}{l} \cdot \frac{1}{r} \cdot \left| 1 - \exp\left(-\frac{r^2}{2\sigma^2}\right) \right|$ 

Estimation of correction:  $\sigma_{corr}^2 \approx \frac{e^2 \ln 2}{4\pi\varepsilon_0 \sqrt{m_r c^2}} \cdot \frac{qN}{l} \cdot d_{gap} \cdot \sqrt{\frac{1}{eU_{er}}} \propto N \cdot d_{gap} \cdot \sqrt{\frac{1}{U_{er}}}$ 

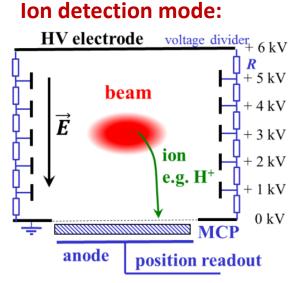
With the measured beam width is given by convolution:  $\sigma_{meas}^2 = \sigma_{true}^2 + \sigma_{corr}^2$ 

*Example:* U<sup>73+</sup>, 10<sup>9</sup> particles per 3 m bunch length, cooled beam with  $\sigma_{true}$  = 1 mm FWHM.

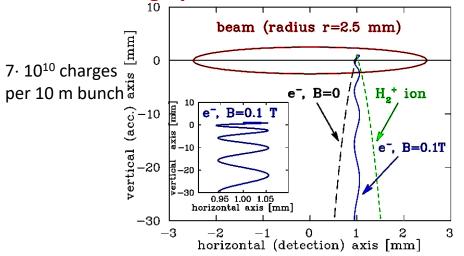


## **Electron Detection and Guidance by Magnetic Field**





#### $\Rightarrow$ broadening by beam's electric field

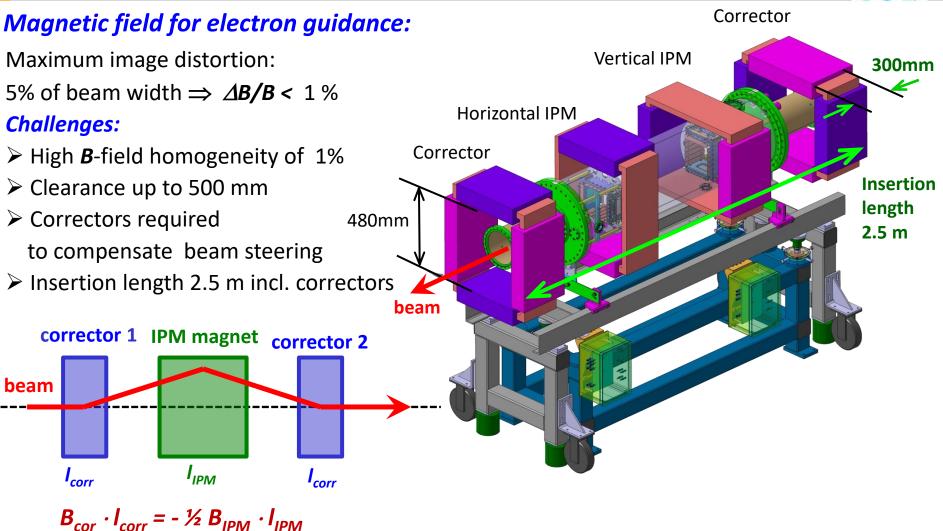


Electron detection mode: HV electrode voltage divider 6 kV R -5 kV -4 kV -3 kV -2 kV -1 kV 0 kVanode position readout

e<sup>-</sup> detection in an external magnetic field  $\rightarrow$  cyclotron radius  $r_C = \frac{mv_\perp}{eB}$ for  $E_{kin,\perp} = 10$  eV & B = 0.1 T  $\Rightarrow r_c \approx 100 \mu m$  $E_{kin}$  from atomic physics,  $\approx 100 \mu m$  resolution of MCP

**Time-of-flight:**  $\approx 1 - 2$  ns  $\Rightarrow 2 - 3$  cycles. **B-field**: Dipole with large aperture  $\rightarrow$  IPM is expensive & large device!

GSI



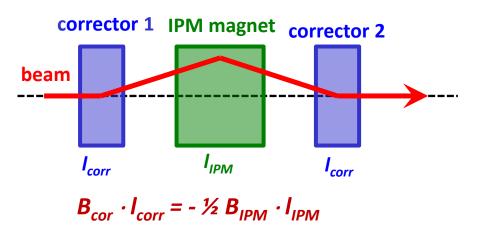
Remark: For MCP wire-array readoutlower clearance required

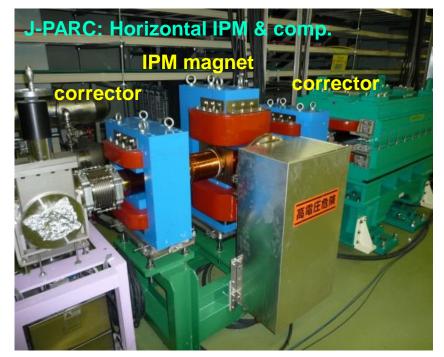


## Magnetic field for electron guidance:

Maximum image distortion: 5% of beam width  $\Rightarrow \Delta B/B < 1\%$ Challenges:

- ➢ High **B**-field homogeneity of 1%
- Clearance up to 500 mm
- Correctors required to compensate beam steering
- ➢ Insertion length 2.5 m incl. correctors





*Magnet: B* = 250 mT, Gap 220 mm IPM: Profile 32 strips, 2.5 mm width

#### **Remark for electron beams:**

Resolution of 50 µm is insufficient, but sometimes used for photon beams

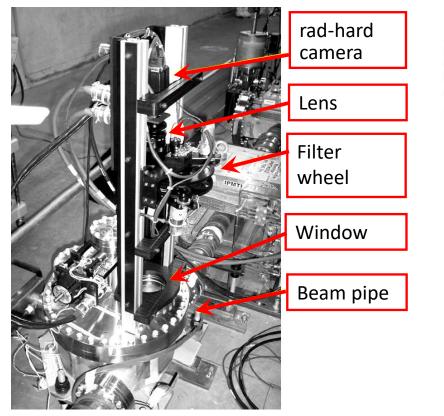
Remark: For MCP wire-array readout lower clearance required



#### *Example* of realization at TERATRON:

Insertion of foil

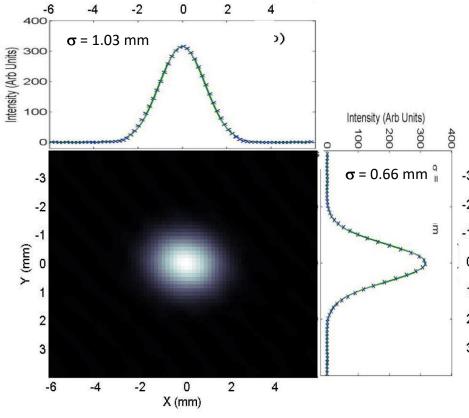
e.g. 5  $\mu$ m Kapton coated with 0.1 $\mu$ m Al Advantage: thin foil  $\Rightarrow$  low heating & straggling 2-dim image visible



Results at FNAL-TEVATRON synchrotron

with 150 GeV proton

Using fast camera: Turn-by-turn measurement



Courtesy V.E. Scarpine (FNAL) et al., BIW'06

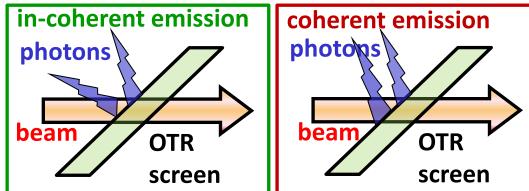
# GS II

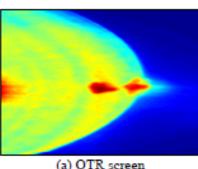
## Observation of coherent OTR for compressed bunches at LINAC based light sources

**Reason:** Coherent emission **if** bunch length  $\approx$  wavelength ( $t_{bunch}$ =2 fs  $\Leftrightarrow$   $I_{bunch}$ =600 nm)

or bunch fluctuations ≈ wavelength Parameter reach for most LINAC-based FELs!

Beam parameter: FLASH, 700 MeV, 0.5 nC, with bunch compression OTR screen scint. screen





(c) LuAG screen

(c) LuAG screen (d) LuAG screen, +100ns delay

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prompt emission for OTR and scint. screen
→ coherent and in-coherent OTR

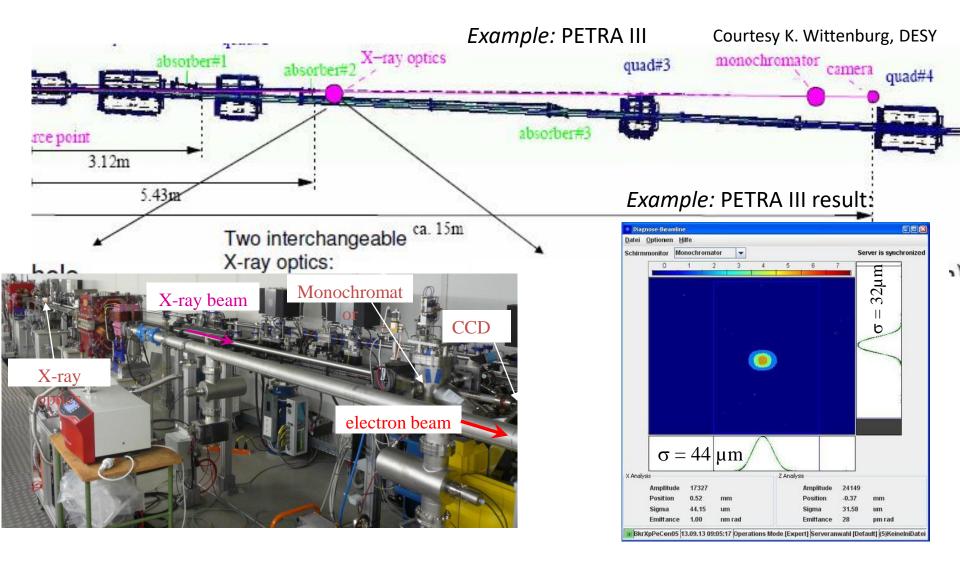
 100 ns delayed emission
 → no OTR as expected (classical process)
 → emission by scint. screen due to lifetime ⇔ correct profile image!

Contrary of M. Yan et al., DIPAC'11 & S. Wesch, DIPAC'11

## X-ray Pin-Hole Camera

GSI

The diffraction limit is  $\Rightarrow \sigma \cong 0.6 \cdot (\lambda^2 / \rho)^{1/3} \Rightarrow$  shorter wavelength by X-rays.

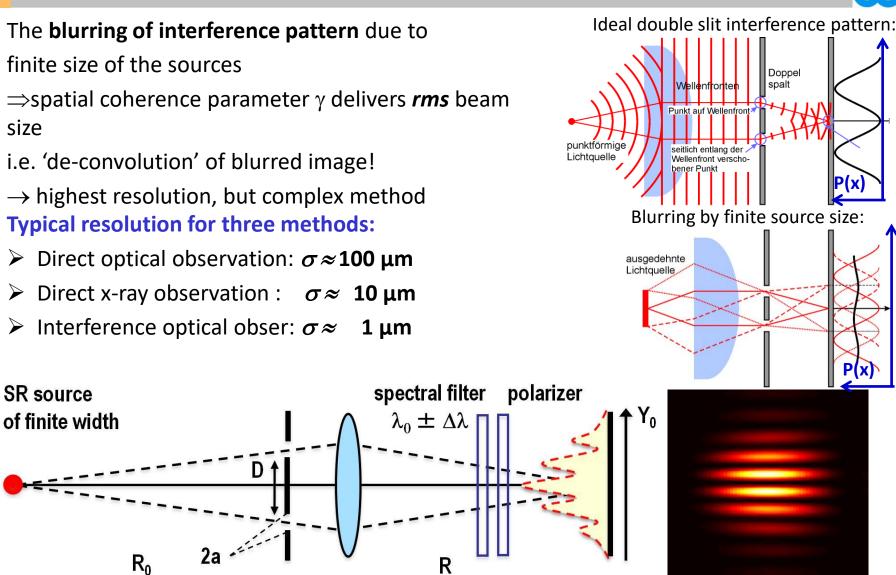


#### Beam Instrumentation & Diagnostics, Part 2

### **Double Slit Interference for Radiation Monitors**



Х



size

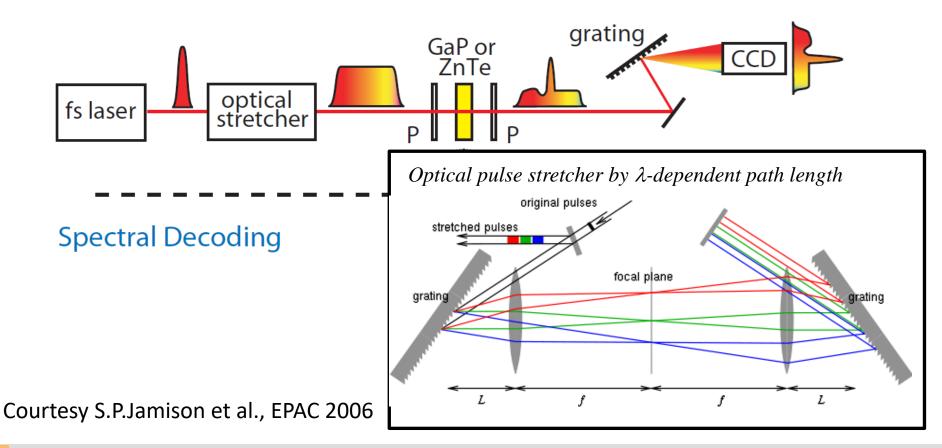
 $\succ$ 



#### For Free Electron Lasers $\rightarrow$ bunch length below 1 ps is achieved

Short laser pulse ⇔ broad frequency spectrum (property of Fourier Transformation) **Optical stretcher**: Separation of colors by different path length

 $\Rightarrow$  different colors at different time  $\Rightarrow$  single-shot observation



#### Bunch Structure at low *E<sub>kin</sub>*: Not possible with Pick-Ups

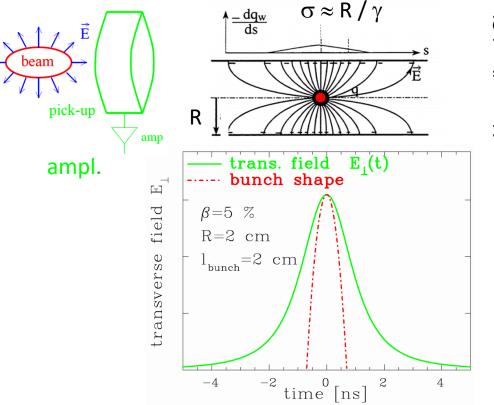


#### Pick-ups are used for:

precise for bunch-center relative to rf
 course image of bunch shape

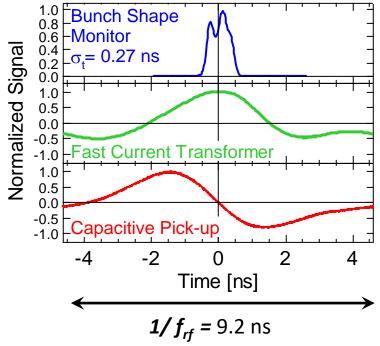
#### **But:**

For  $\beta << 1 \rightarrow$  long. *E*-field significantly modified:



*Example*: Comparison pick-up – particle counter:

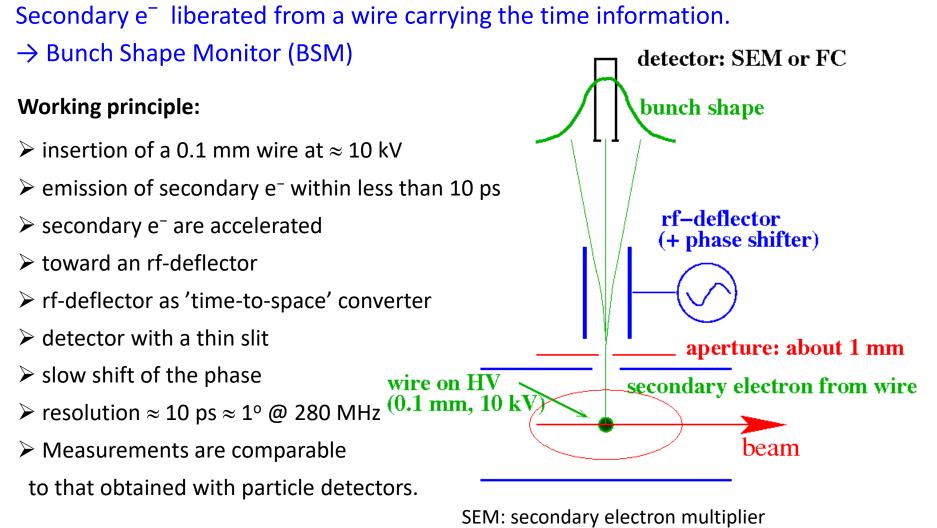
Ar beam of 1.4 MeV/u ( $\theta$  = 5.5%) ,  $f_{rf}$  = 108 MHz



 $\Rightarrow$  the pick-up signal is insensitive to bunch 'fine-structure'

#### Bunch Structure using secondary Electrons for low Ekin Protons

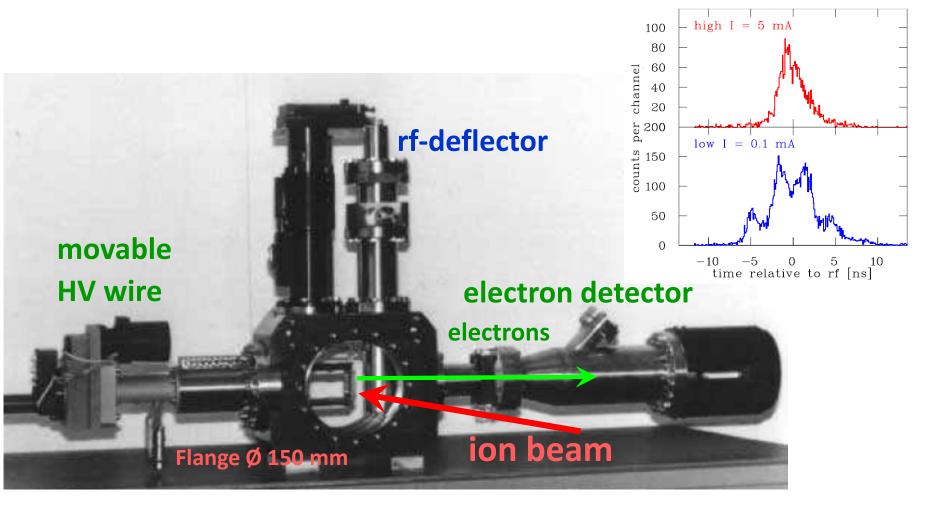




#### **Realization of Bunch Shape Monitor at CERN LINAC2**



*Example:* The bunch shape behind RFQ with120 keV/u:



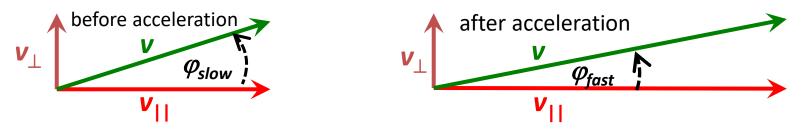
Peter Forck, CAS 2024, Santa Susanna

77 → back: Conclusion Beam Instrumentation & Diagnostics, Part 2

#### 'Adiabatic' Damping during Acceleration







After acceleration the longitudinal velocity is increased  $\Rightarrow$  angle  $\varphi$  is smaller The angle is expressed in momenta:  $x' = p_{\perp} / p_{\parallel}$  the emittance is  $\langle xx' \rangle = 0$ :  $\varepsilon = x \cdot x' = x \cdot p_{\perp} / p_{\parallel}$  $\Rightarrow$  under ideal conditions the emittance can be normalized to the momentum  $p_{\parallel} = \gamma \cdot m \cdot \beta c$  $\Rightarrow$  normalized emittance  $\varepsilon_{norm} = \beta \gamma \cdot \varepsilon$  is preserved with the Lorentz factor  $\gamma$  and velocity  $\beta = v/c$ **Example:** Acceleration in GSI-synchrotron for C<sup>6+</sup> from шш injection 1.2  $6.7 \rightarrow 600 \text{ MeV/u} \ (\beta = 12 \rightarrow 79 \%) \text{ observed by IPM}$ 1.0 distribution theoretical width:  $\langle x \rangle_f = \sqrt{\frac{\beta_i \cdot \gamma_i}{\beta_f \cdot \gamma_f}} \cdot \langle x \rangle_i$ =0.23 s vidth at extraction 2 0.8 0.1.2.3.4.5.6  $= 0.33 \cdot \langle x \rangle_i$ 0.6 time [s **IPM** norm. measured width:  $\langle x \rangle_f \approx 0.37 \cdot \langle x \rangle_i$ 0.4 synchrotron with IPM is well suited acceleration 0.2 for long time observations 0.0 without beam disturbance -200 20 40 -40coordinate [mm] injection extraction.  $\rightarrow$  mainly used at proton synchrotrons

Peter Forck, CAS 2024, Santa Susanna

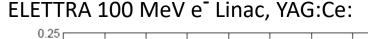
78 *→magnetic field* Beam Instrumentation & Diagnostics, Part 2

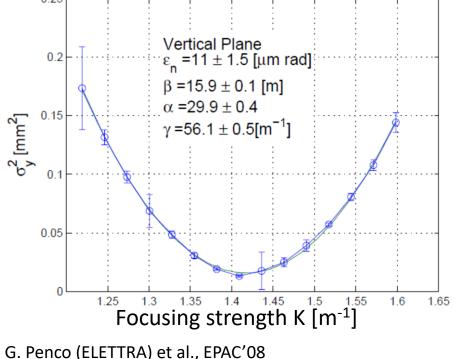
GSX COO

Using the 'thin lens approximation' i.e. the quadrupole has a focal length of *f*:

$$\mathbf{R}_{focus}(K) = \begin{pmatrix} \mathbf{1} & \mathbf{0} \\ -\mathbf{1}/f & \mathbf{1} \end{pmatrix} \equiv \begin{pmatrix} \mathbf{1} & \mathbf{0} \\ K & \mathbf{1} \end{pmatrix} \implies \mathbf{R}(L, K) = \mathbf{R}_{drift}(L) \cdot \mathbf{R}_{focus}(K) = \begin{pmatrix} \mathbf{1} + LK & L \\ K & \mathbf{1} \end{pmatrix}$$

Measurement of matrix-element  $\sigma_{11}(s_1, K)$  from matrices  $\sigma(s_1, K_i) = \mathbf{R}(K_i) \cdot \sigma(s_0) \cdot \mathbf{R}^{\mathsf{T}}(K_i)$ **Example:** Square of the beam width at





For completeness: The relevant formulas  $\sigma_{11}(1, K) = L^2 \sigma_{11}(0) \cdot K^2$   $+ 2 \cdot (L \sigma_{11}(0) + L^2 \sigma_{12}(0)) \cdot K$   $+ L^2 \sigma_{22}(0) + \sigma_{11}(0)$   $= a \cdot K^2 - 2ab \cdot K + ab^2 + c$ 

$$= a \cdot \mathbf{K} - 2ab \cdot \mathbf{K} + ab + c$$
$$= a \cdot (K - b)^2 + c$$

The three matrix elements at the quadrupole:  $\sigma_{11}(0) = \frac{a}{L^2}$   $\sigma_{12}(0) = -\frac{a}{L^2} \left(\frac{1}{L} + b\right)$   $\sigma_{22}(0) = \frac{1}{L^2} \left(ab^2 + c + \frac{2ab}{L} + \frac{a}{L^2}\right)$   $\varepsilon_{rms} \equiv \sqrt{\det \sigma(0)} = \sqrt{\sigma_{11}(0) \cdot \sigma_{22}(0)} - \frac{\sigma_{12}^2(0)}{\sigma_{12}^2(0)} = \sqrt{ac} / L^2$ 

### The Emittance for Gaussian and non-Gaussian Beams

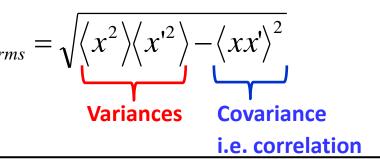


#### The beam distribution can be non-Gaussian, e.g. at:

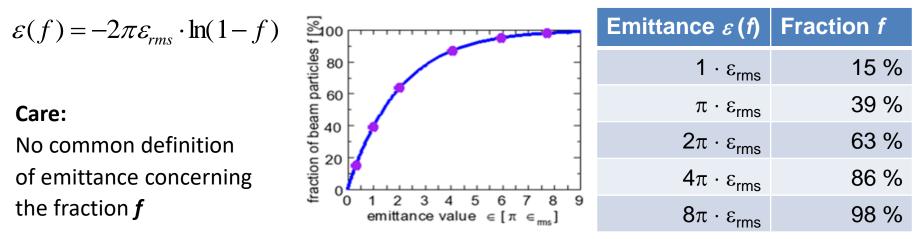
- Beams behind ion source
- Space charged dominated beams at LINAC & synchrotron
- Cooled beams in storage rings

General description of emittance by statistical moments of 2-dim distribution:  $\mathcal{E}_{rms}$ 

It describes the value for 1 standard derivation

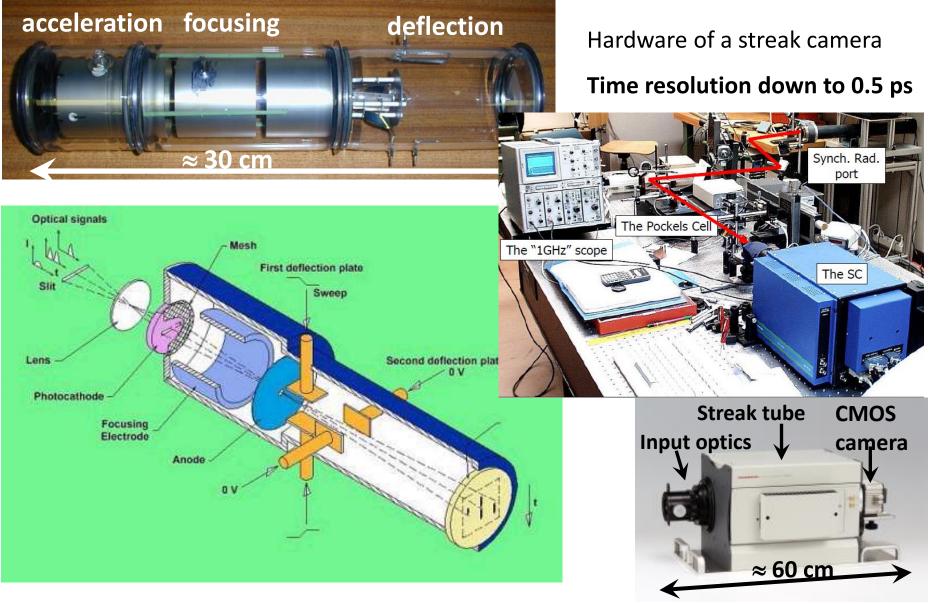


For <u>Gaussian</u> beams only:  $\varepsilon_{rms} \leftrightarrow$  interpreted as area containing a fraction **f** of ions:



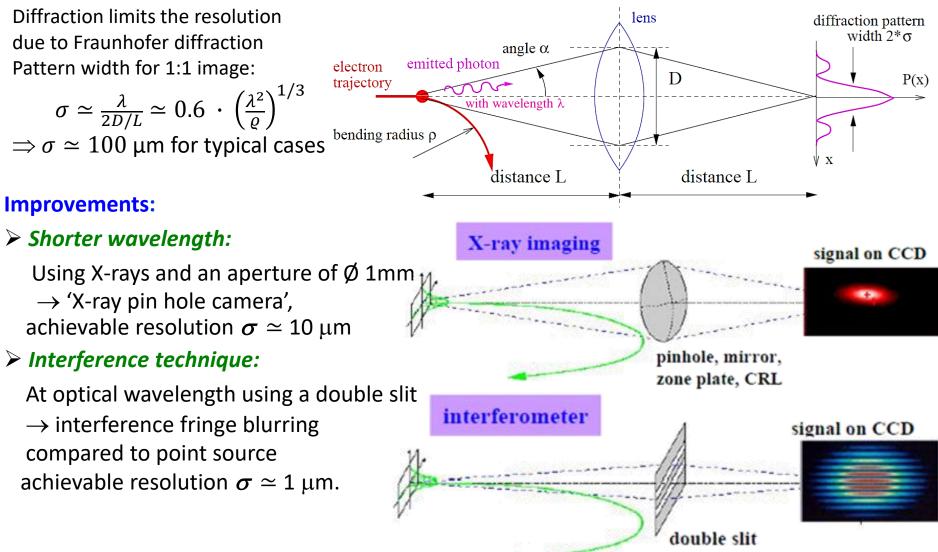
#### **Technical Realization of a Streak Camera**





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#### Limitations:



#### **Basic idea for Beam Loss Monitors BLM:**

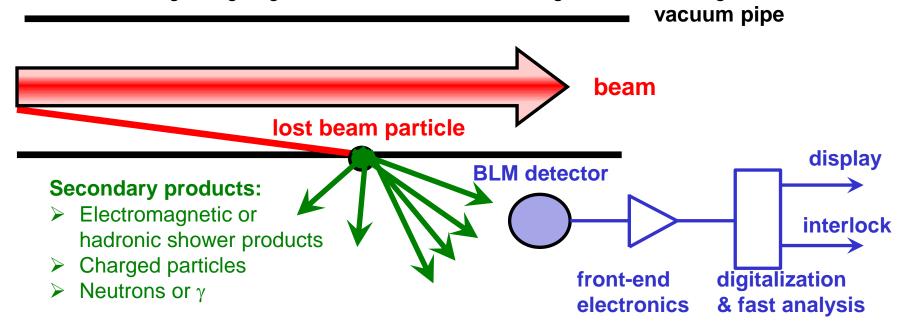
A loss beam particle must collide with the vacuum chamber or other insertions

 $\Rightarrow$  Interaction leads to some shower particle:

e<sup>-</sup>, γ, protons, neutrons, excited nuclei, fragmented nuclei

- $\rightarrow$  Detection of these secondaries by an appropriate detector outside of beam pipe
- $\rightarrow$  Relative cheap detector installed at many locations

Remark: Due to grazing angle a thin vacuum chamber might be a 'thick target'





#### **Plastics or liquids are used:**

- Detection of charged particles by electronic stopping
- Detection of neutrons by elastic collisions n on p in plastics and fast p electronic stopping.

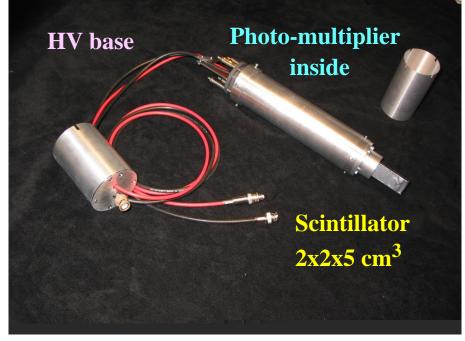
#### Scintillator + photo-multiplier:

counting (large PMT amplification) or analog voltage ADC (low PMT amplification) Radiation hardness: plastics 1 Mrad =  $10^4$  Gy liquid  $10 \text{ Mrad} = 10^5 \text{ Gy}$ 

STRAHLAUSLENKUNG

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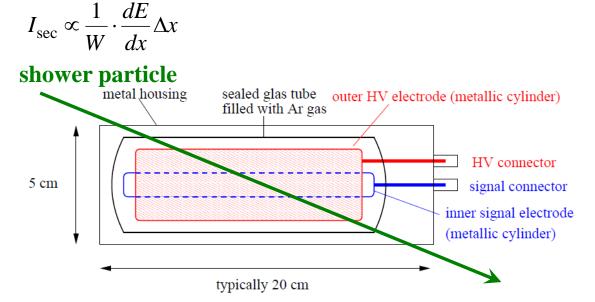








#### Energy loss of charged particles in gases $\rightarrow$ electron-ion pairs $\rightarrow$ current meas.



### *W* is average energy for creation for one $e^{-}$ -ion pair:

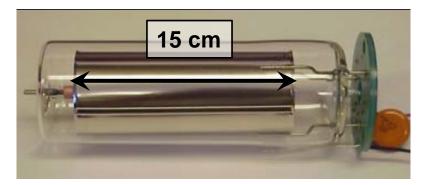
Gas	Ionization Pot. [eV]	W-Value [eV]
Ar	15.7	26.4
$N_2$	15.5	34.8
O <sub>2</sub>	12.5	30.8
Air		33.8

#### Sealed tube Filled with Ar or $N_2$ gas:

- Creation of Ar+-e<sup>-</sup> pairs, average energy W = 32 eV/pair
- measurement of this current
- Slow time response

due to  $\approx$  10 µs drift time of Ar<sup>+</sup>.

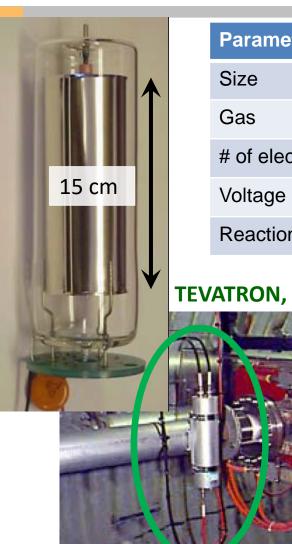
#### Per definition: Direct measurement of dose !



#### **Ionization Chamber as BLM: TEVATRON and CERN Type**



38 cm



Parameter	TEVATRON, RHIC	CERN type	
Size	15cm, $\varnothing$ 6 cm	50 cm, $\varnothing$ 9 cm	
Gas	Ar at 1.1 bar	N <sub>2</sub> at 1.1 bar	
# of electrodes	3	61	
Voltage	1000 V	1500 V	
Reaction time	3 µs	0.3 µs	
4000 BLMs at LHC⇔ each ≈ 6m			

#### **TEVATRON, RHIC type**

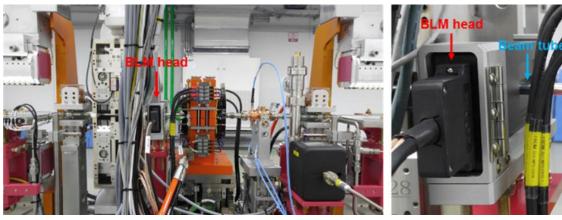
**CERN type** 

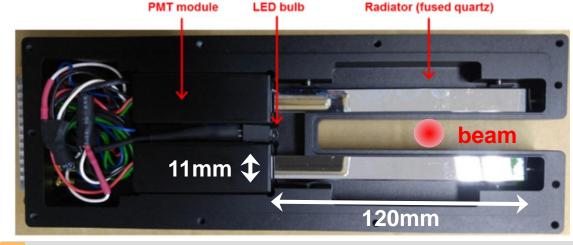
#### **Cherenkov Light Detectors** as Beam Loss Monitors



#### **Cherenkov detectors:**

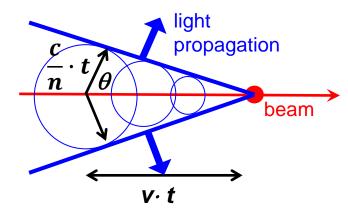
Passage of a charged particle v faster than propagation of light  $v > c_{medium} = c / n$ **Technical:** Quartz rod n=1.5 & photomultiplier Example: Korean XFEL behind undulator





#### **Cherenkov light emission:**

For  $v > c_{medium} = c / n$ light wave-front like a wake broadband light emission



#### Advantage:

Detection of fast electrons only

not sensitive to  $\gamma$  & synch. photons

- No saturation effects
- Prompt light emission
   Usage: Mainly at FELs for short and intense pulses

H. Yang, D.C. Shin, FEL Conf. 2017

Peter Forck, CAS 2024, Santa Susanna

## Different detectors are sensitive to various physical processes very different count rate, but basically proportional to each other

#### Typical choice of the detector type:

Ionization Chamber:

#### Advantage:

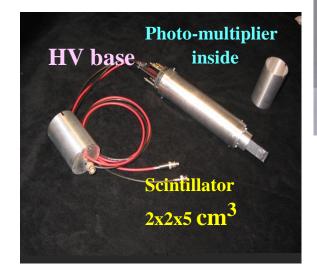
- Measurement of absolute dose

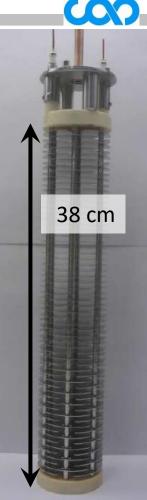
#### **Disadvantage:**

- Low signal (low  $\gamma$ , eff, no neutron detection),
- Sometimes slow, ion drift time 10 ... 100  $\mu s$
- $\Rightarrow$  Often used at **proton** accelerators

#### Scintillator, Cherenkov detector: Advantage:

- Fast current reading or particle counting
- Can be fabricated in any shape, cheap **Disadvantage:**
- Need calibration in many cases
- Might suffer from radiation
- $\Rightarrow$  Often used at **electron** accelerators





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